

A programmable metrological standard based on the quantum Hall effect

Laurea Magistrale in Fisica della Materia

Luigi Caputo

Appello di maggio 2021



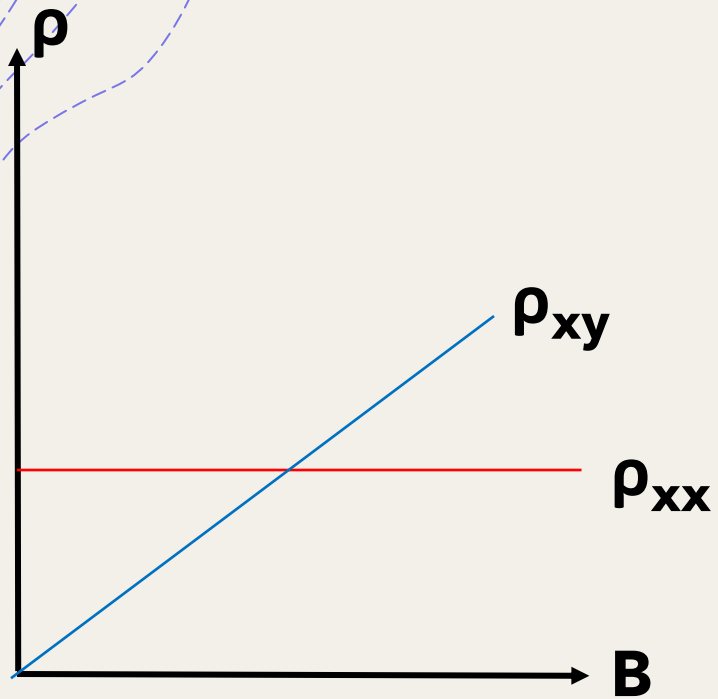
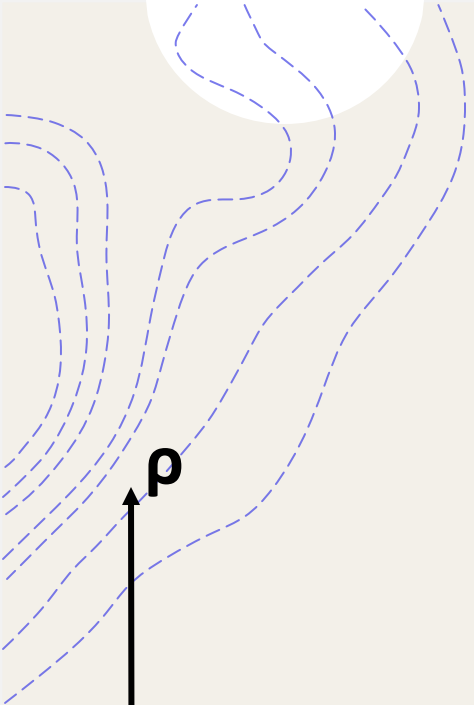
NEST

National Enterprise for nanoScience
and nanoTechnology

Presentation outline

- 1) The quantum Hall effect & quantum Hall Metrology**
- 2) Novel device
- 3) Experimental results
- 4) Numerical results
- 5) Conclusions and perspectives

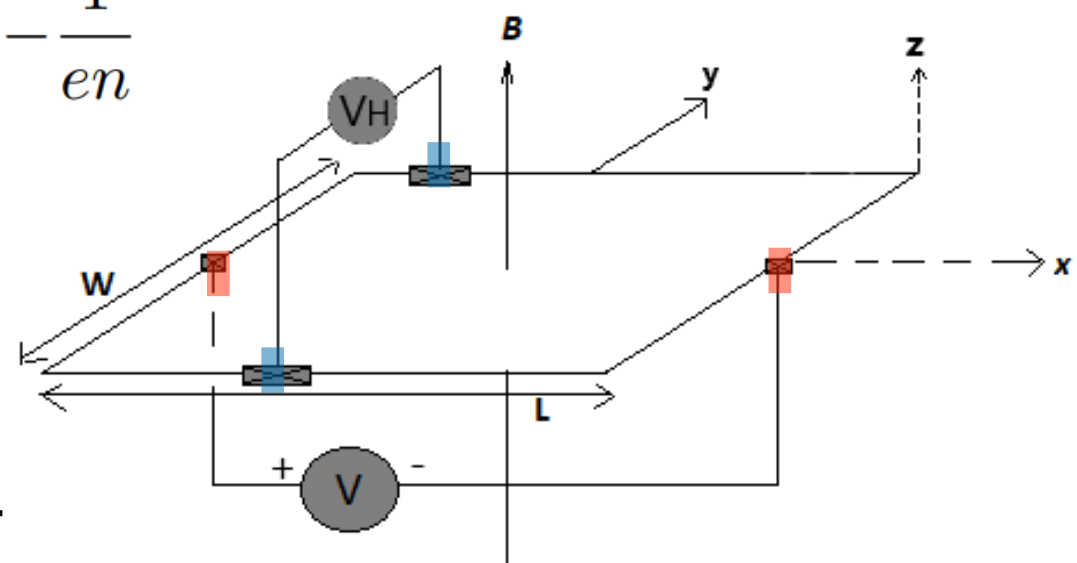
(Quantum) Hall effect phenomenology



2D conductor ←

$$\rho_{xy} = \frac{B}{en}$$
$$\rho_{xx} = \frac{m^*}{\tau e^2 n}$$
$$R_H \equiv \frac{\rho_{yx}}{B} = -\frac{1}{en}$$

→ Drude theory

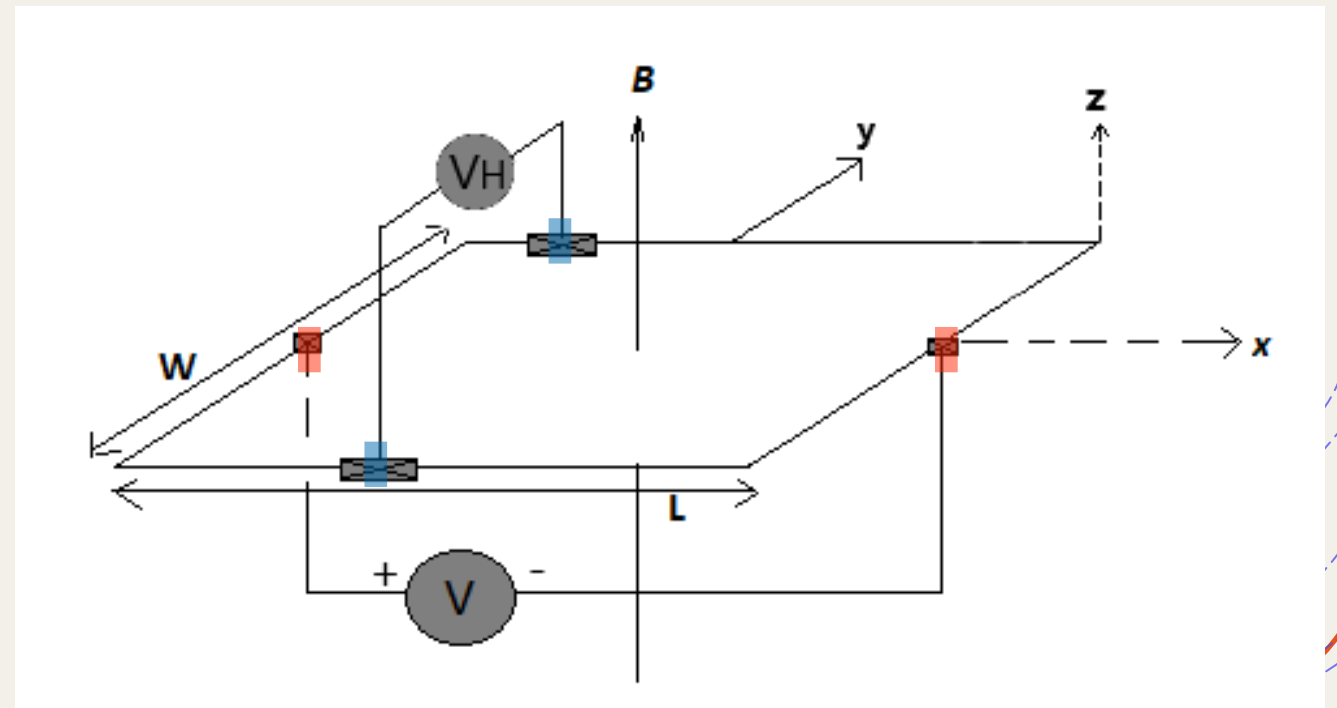
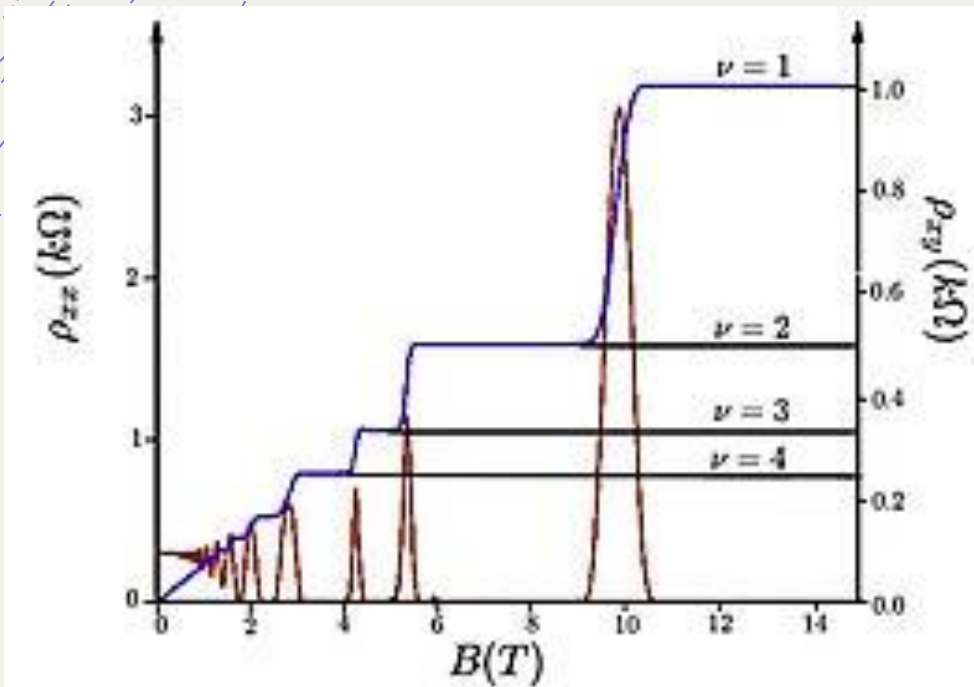


$$\nu = \frac{n\hbar}{eB}$$

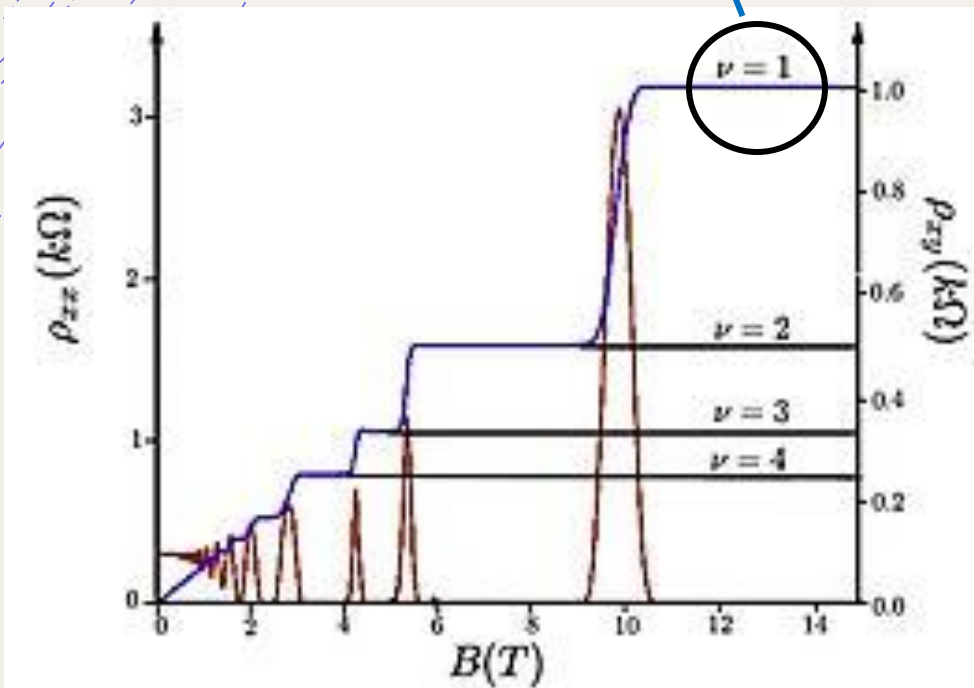
Fundamental constants
dependence

$$\rho_{xy} = \frac{1}{\nu} \frac{h}{e^2}$$

$$\mathbf{R}_H = \mathbf{R}_K / \nu$$



$R_K = 25.81280755710 \text{ k}\Omega$
Verified up to 11 decimal figures

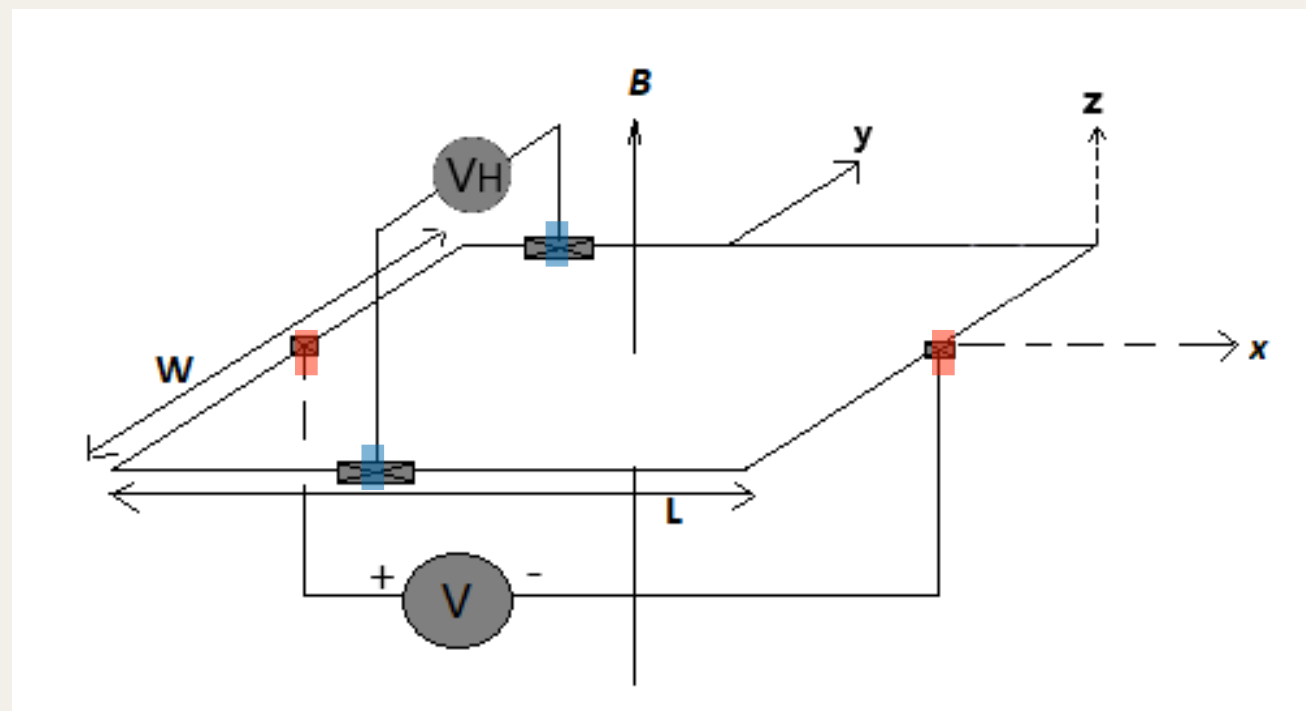


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Fundamental constants dependence

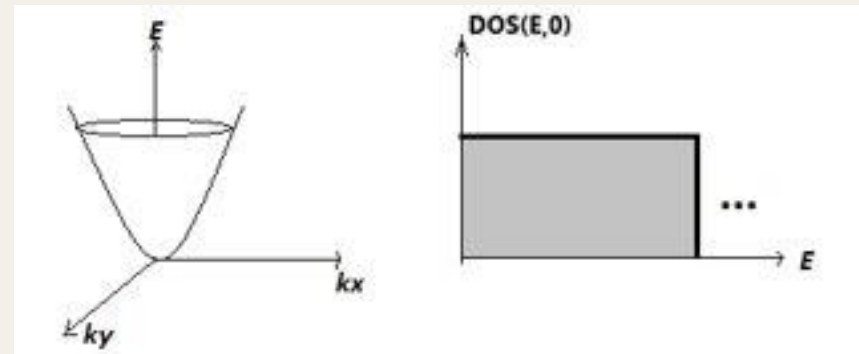
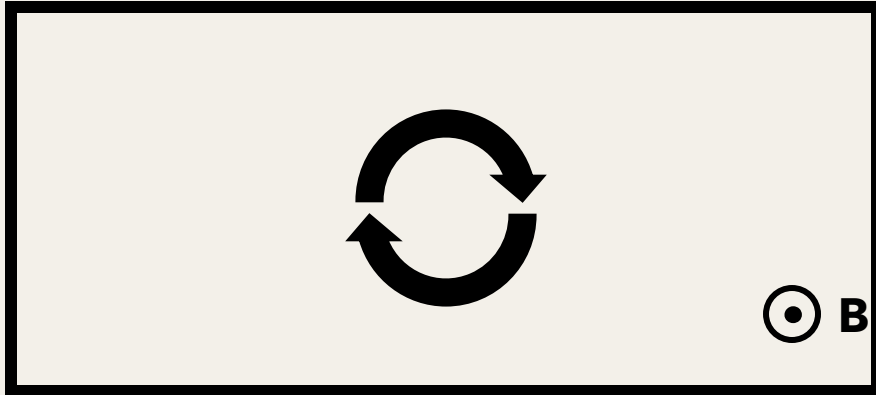
$$\rho_{xy} = \frac{1}{\nu} \frac{h}{e^2}$$

$$R_H = R_K / \nu$$



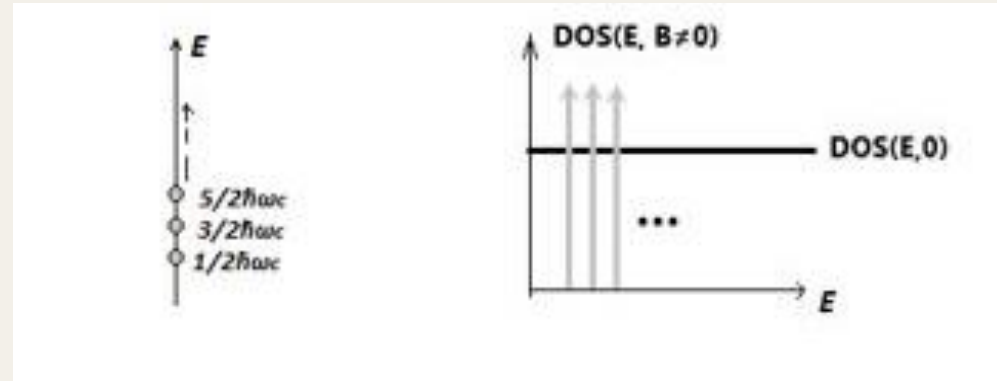
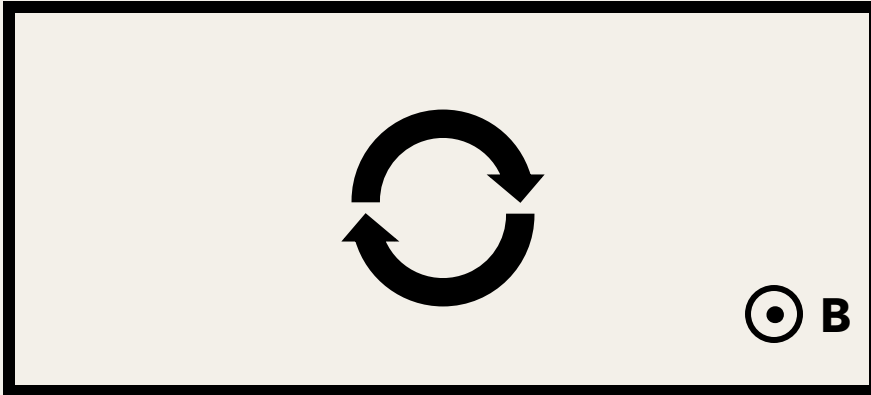
Quantum Hall effect physics

Integer quantum Hall ← Cyclotron orbits quantization (Landau levels)



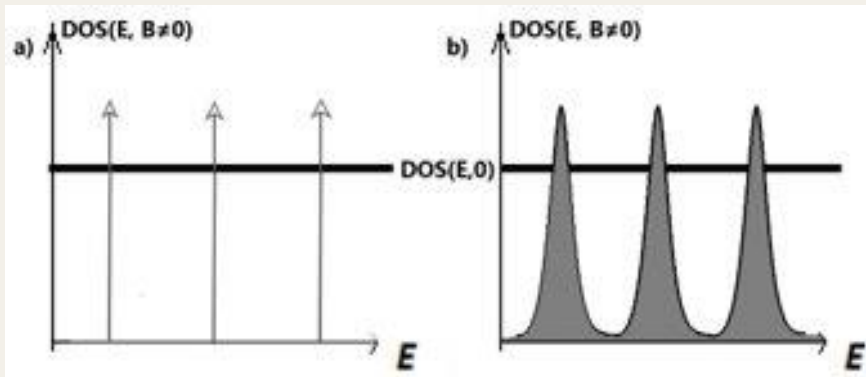
Quantum Hall effect physics

Integer quantum Hall ← Cyclotron orbits quantization (Landau levels)

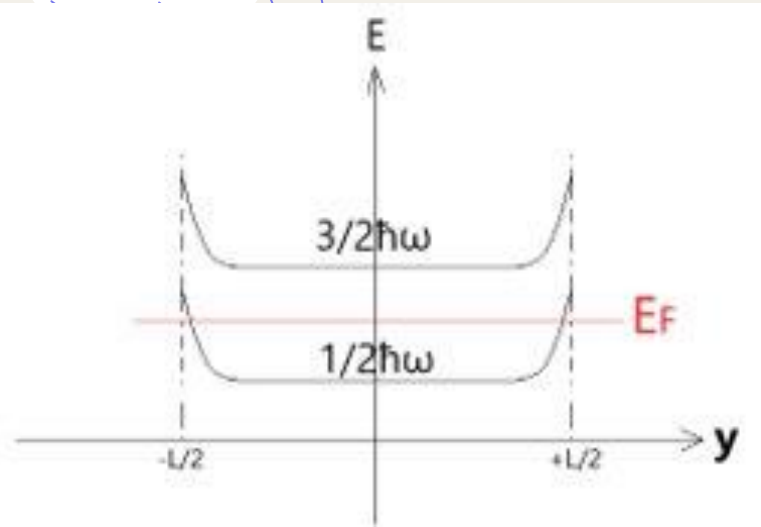


$$\Delta E = \hbar\omega_c \propto B$$

With disorder

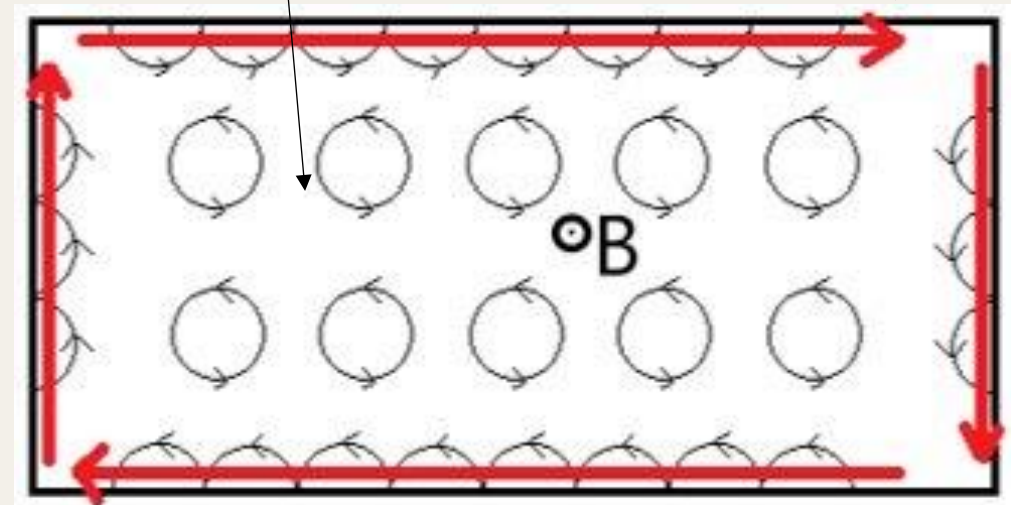
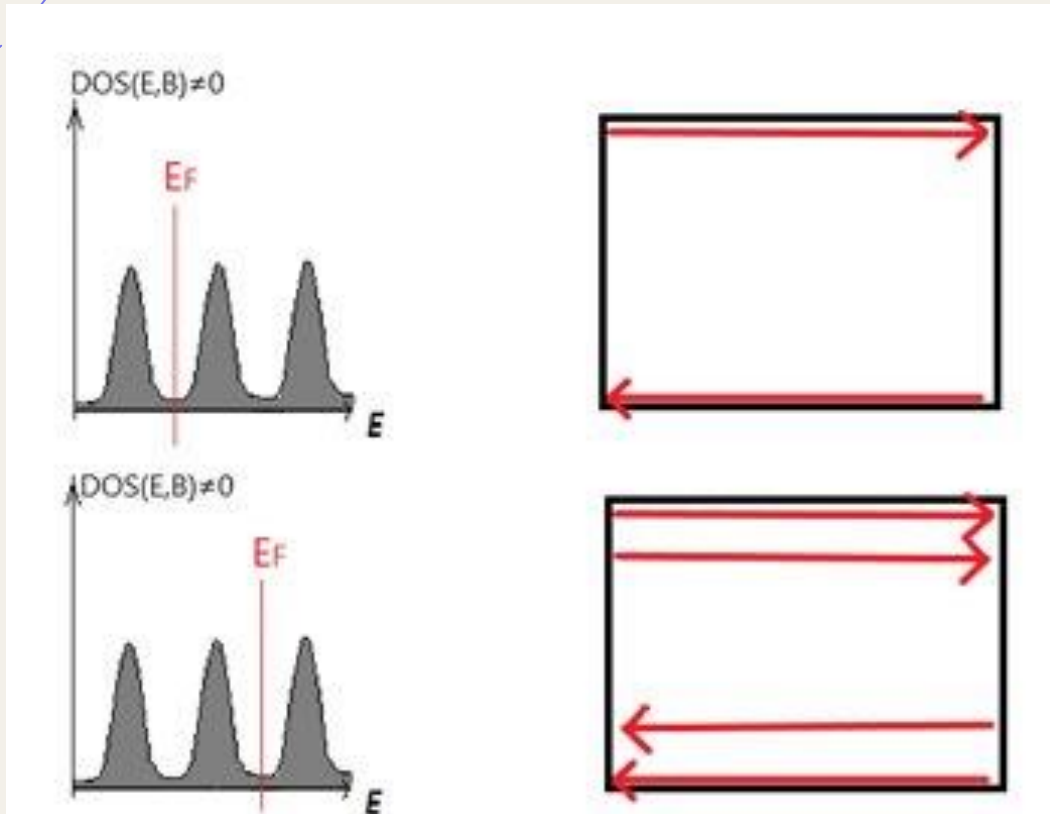


Quantum Hall effect physics

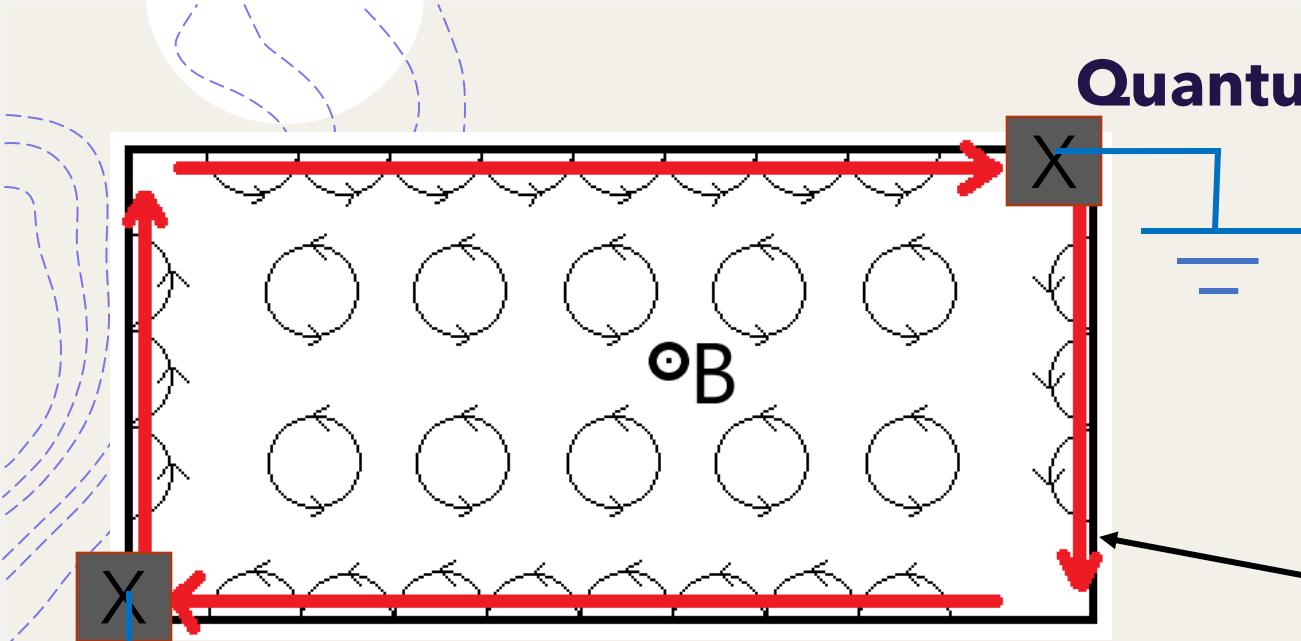


Insulator in the bulk

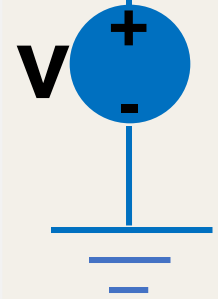
Conductor at the edges



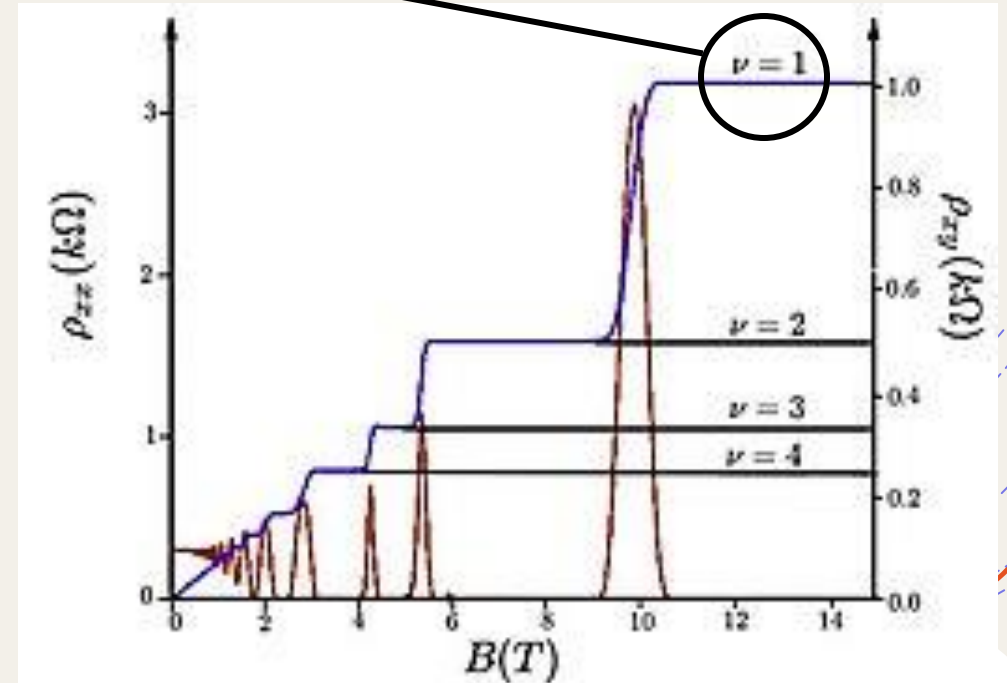
Quantum Hall effect physics



$$\mu_R - \mu_L = (-e)V$$
$$I = (-e) \int_{k_L}^{k_R} v_x(k) \frac{dk}{2\pi} = \frac{e^2}{2\pi\hbar} \int_{\mu_L}^{\mu_R} dE(k) = \frac{e^2}{h} V$$
$$R_{1edge} = \frac{V}{I} = \frac{h}{e^2} = R_K$$



ν = number of propagating 1D modes at the edges and Landau levels occupied.



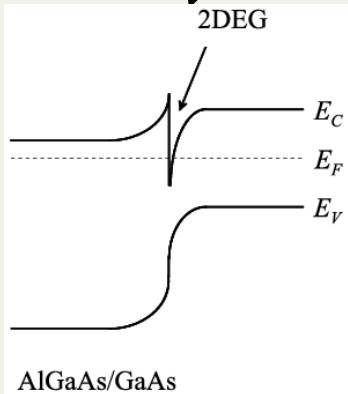
Quantum Hall metrology



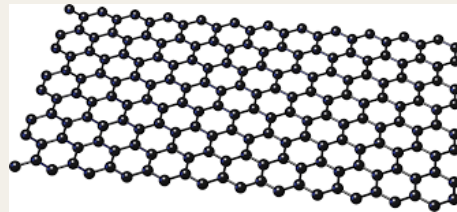
QH universality tests

← **Electrical resistance metrology** →

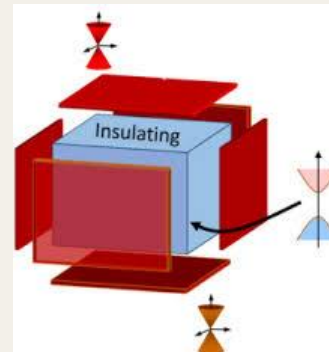
Resistance calibration



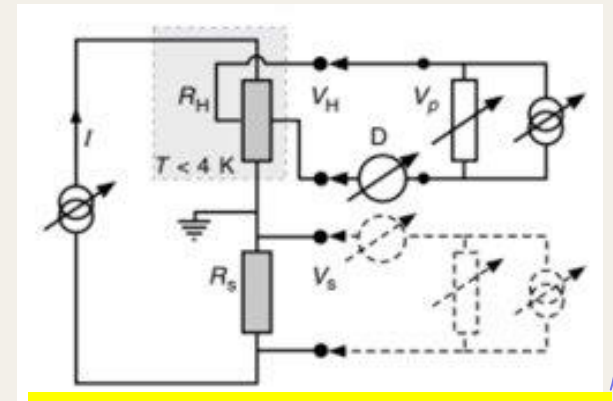
2D electron gas in heterostructures



2D materials like graphene

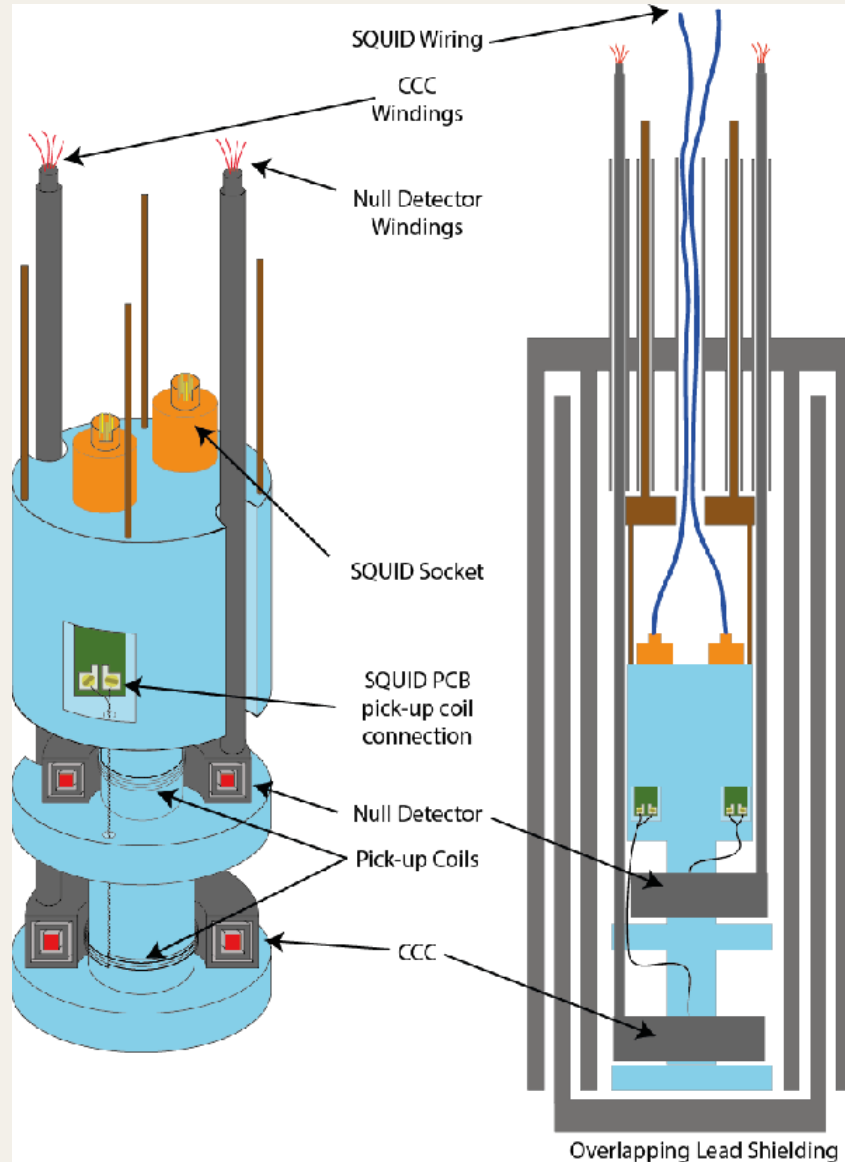


**Topological insulators
Spin QH effect at B=0**



How to compare resistances different from R_K without losing precision ? ...

... Comparing currents with high precision



CCCs

Cryogenic Current Comparators

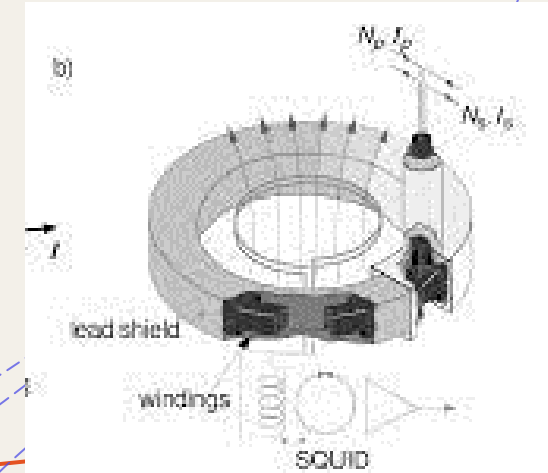
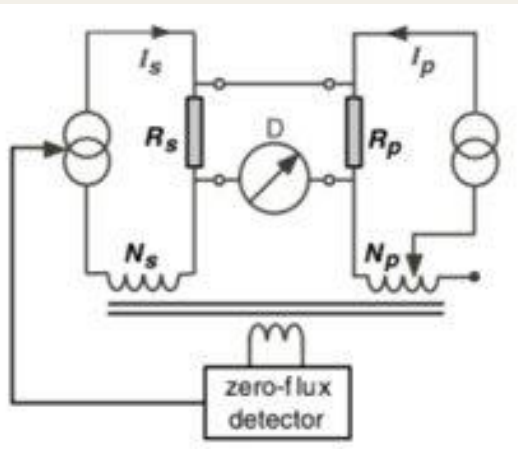
Advantages:

- Very high precision due to SQUID magnetometers

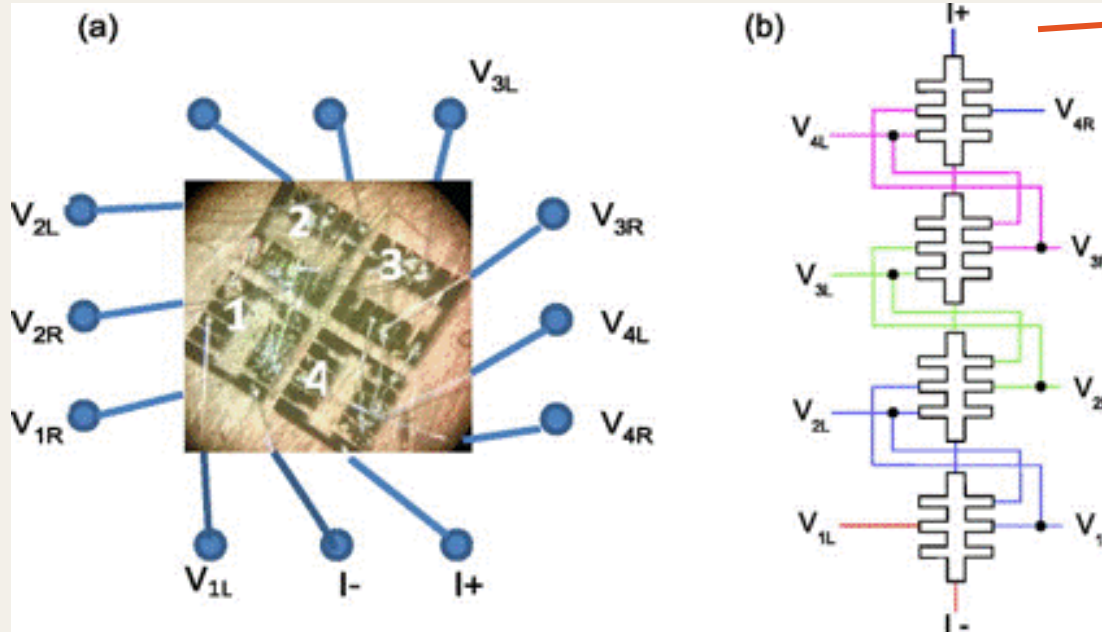
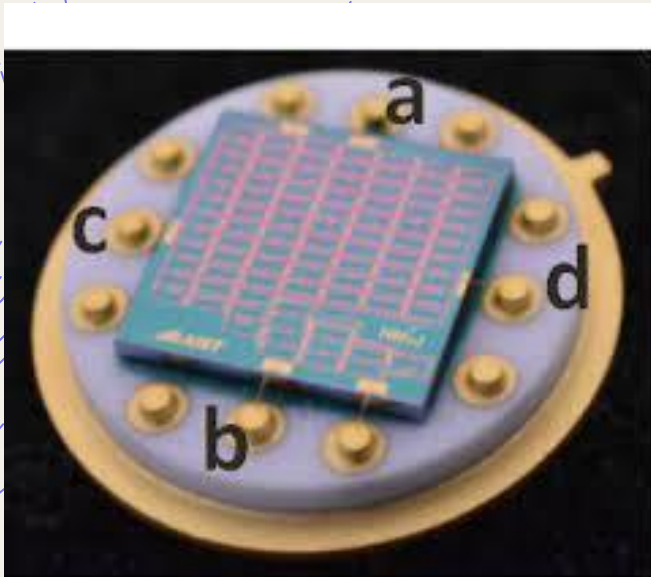
Problems:

- **Intricate setup**
- **Incompatibility of measuring apparatus with the presence of a magnetic field**

Separate insulated cryogenic setup for the SQUID



... Generating new standards by scaling R_K value



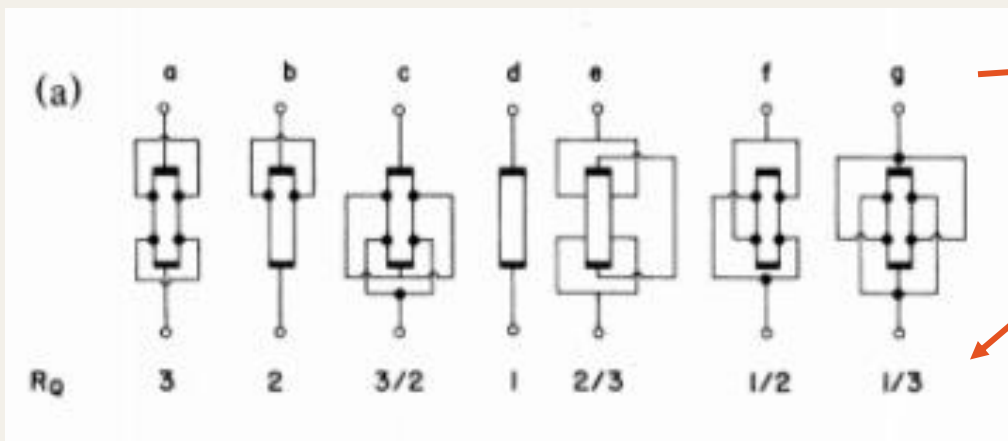
QHARS:
Quantum Hall Array
Resistance Standard

Advantages:

- Conventional cryogenic setup

Problems:

- **Presence of Ohmic resistances**
- **One standard per device**
- **Number of standards scales with the number of elements**



Hall bar with multiple lateral shorts:

- **Few fractions of R_K obtainable**

... Are there other ways ?

Presentation outline

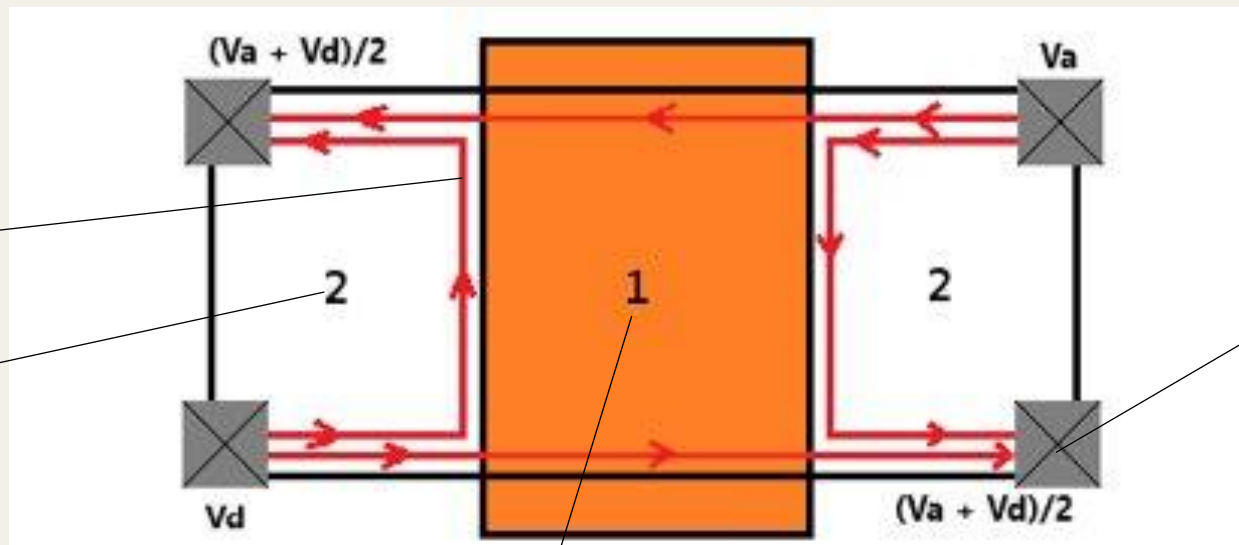
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Building block

New way to obtain more R_K fraction with less elements without Ohmic connections

Cascaded Quantum Hall Bisection and Applications to Quantum Metrology
Zahra Sadre Momtaz, Stefan Heun, Giorgio Biasiol, and Stefano Roddaro
Phys. Rev. Applied **14**, 024059 – Published 20 August 2020

Edge mixer



Edge reflection

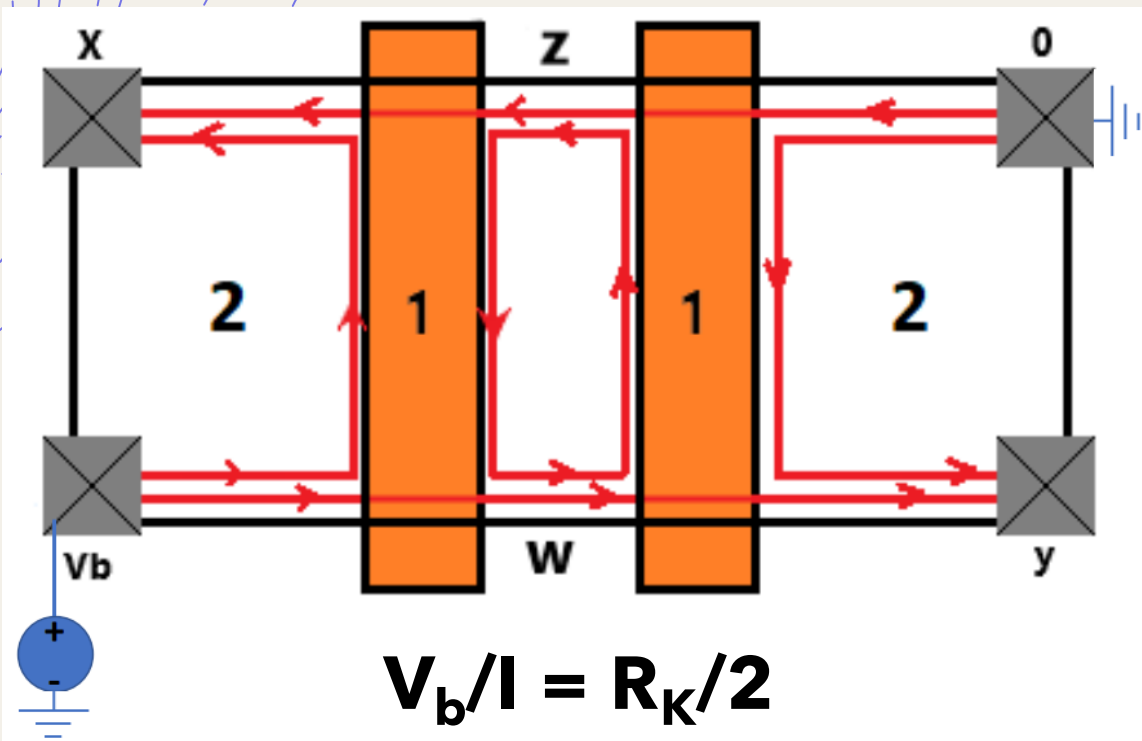
$\nu = 2$

Average of input voltages V_d and V_a

Equilibrating edges coming from different regions

ν -Reconfigurable region

Two barriers in series

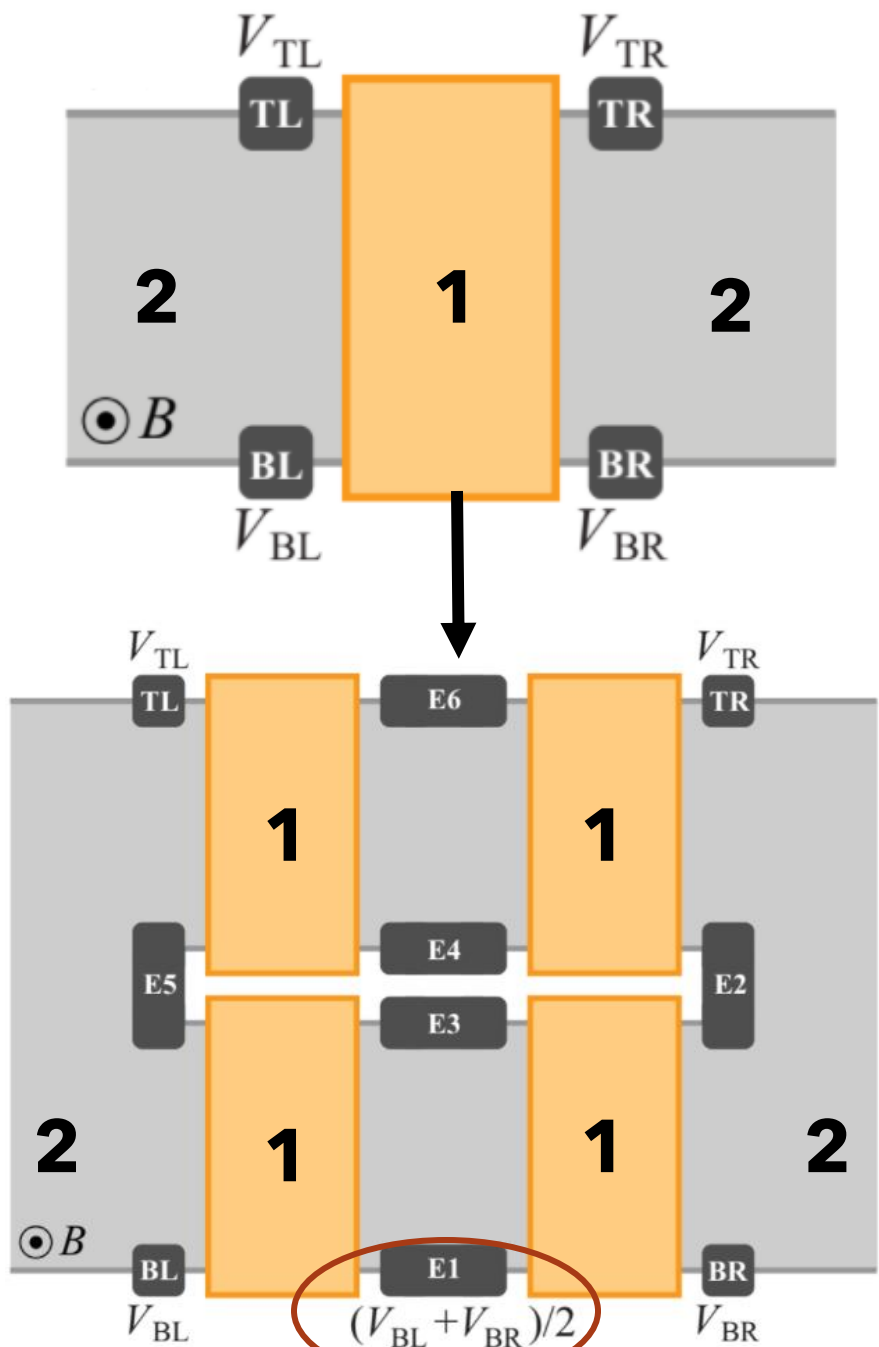


$$\begin{cases} x = \frac{V_b}{2} + \frac{z}{2} \\ y = z = \frac{w}{2} \end{cases}$$

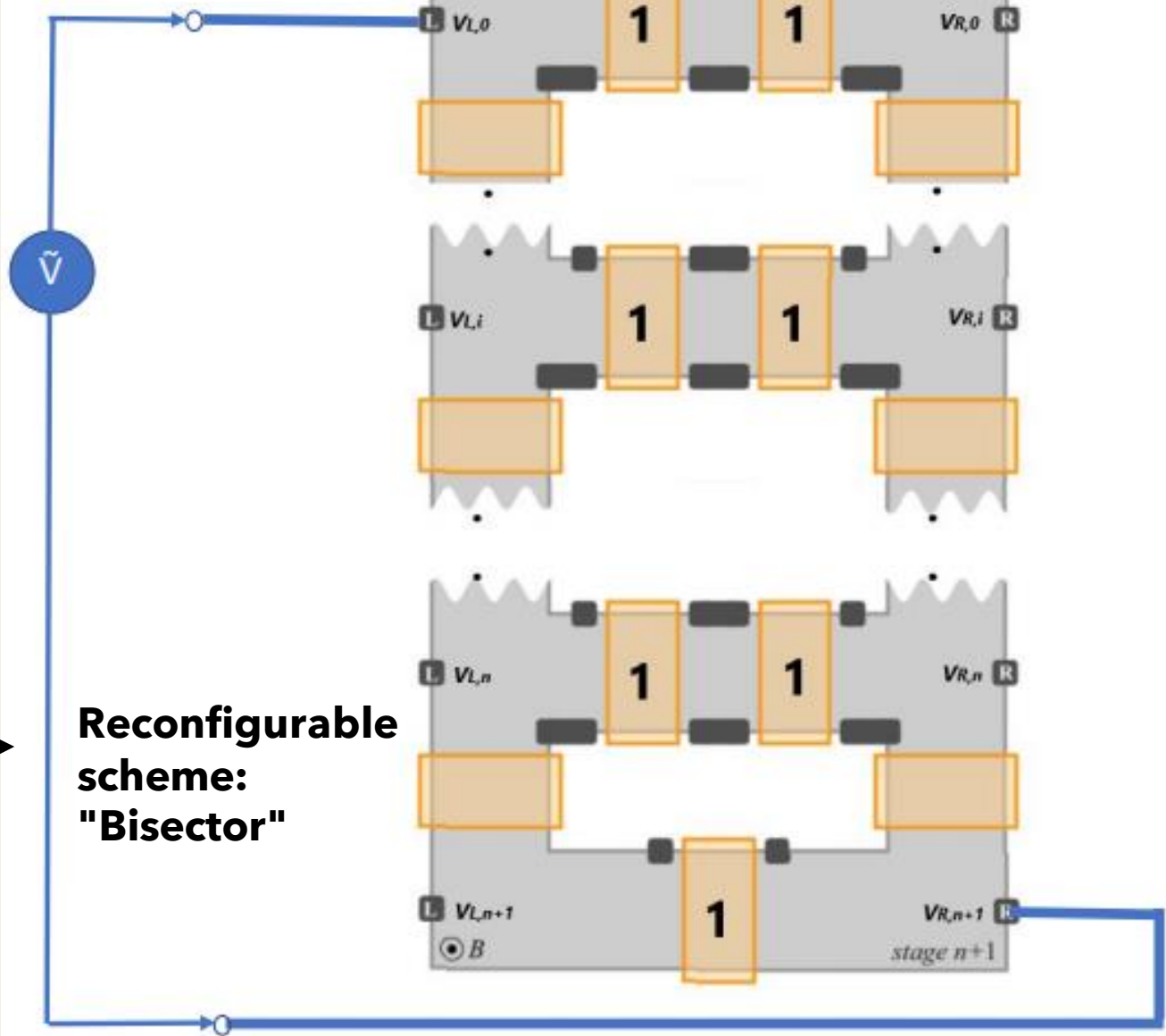
$$y - x = -\frac{V_b}{3}$$

$$V_b - y = \frac{2V_b}{3}$$

Various fractions generated without interconnected elements.



$$\frac{\tilde{V}}{I} = \frac{R_K}{2} \frac{k}{2^n}$$



Recap and thesis targets

Open problems in resistive metrology



Solved with the scheme in the paper

- Generating ad hoc standards on the same device
- Stray resistances due to interconnected elements
- Reduce the number of elements and increase number of standards
- Double cryogenic setup for CCC

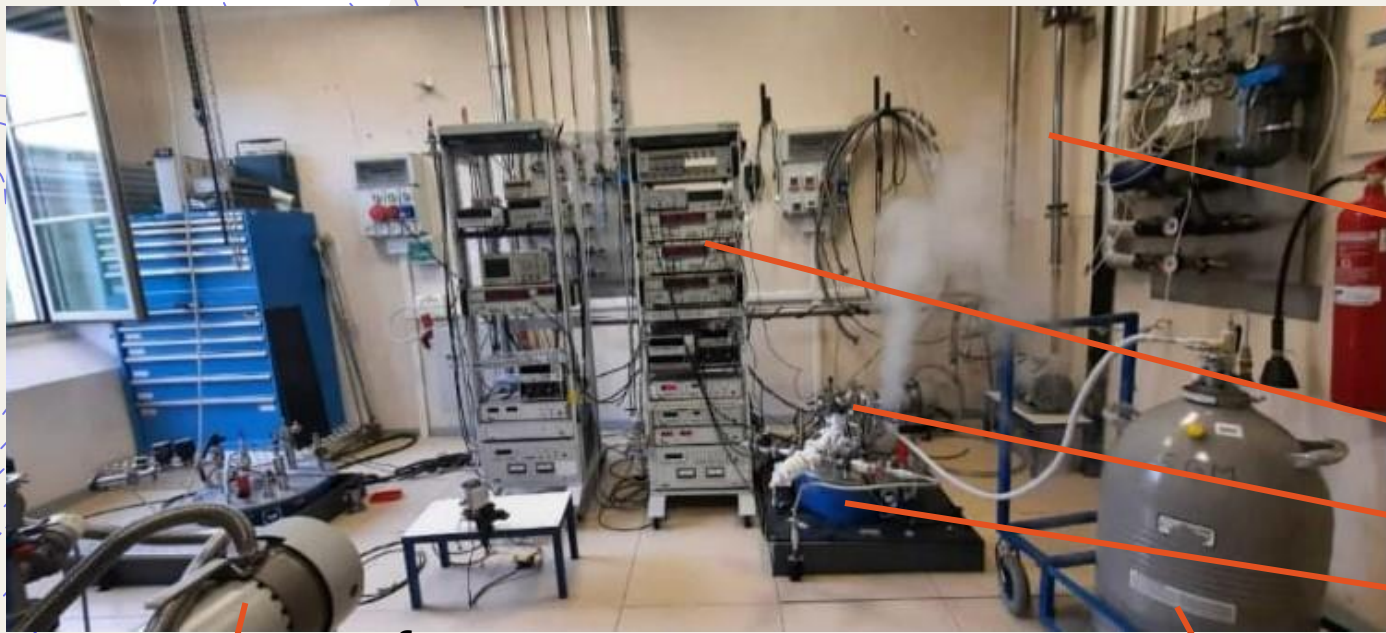
Open questions in the article studied

- How precise is the edge mixing ?**
- Large voltage bias or current is need to achieve high precision: What is the maximum voltage applicable to the new device ? (breakdown voltage)**

Presentation outline

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Lab and cryogenic setup



Other cryostat insert

Lock-ins

He-3 Cryostat



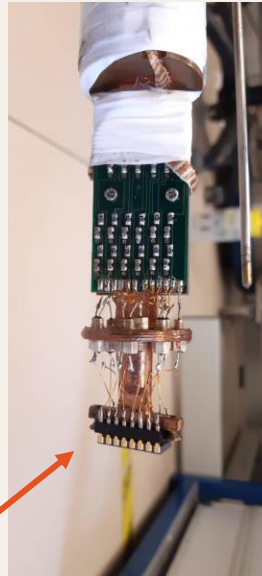
Minimum temperature
Around 300 mK

Pump for vacuum

N2 refilling tank

1K pot
Cryostat insert

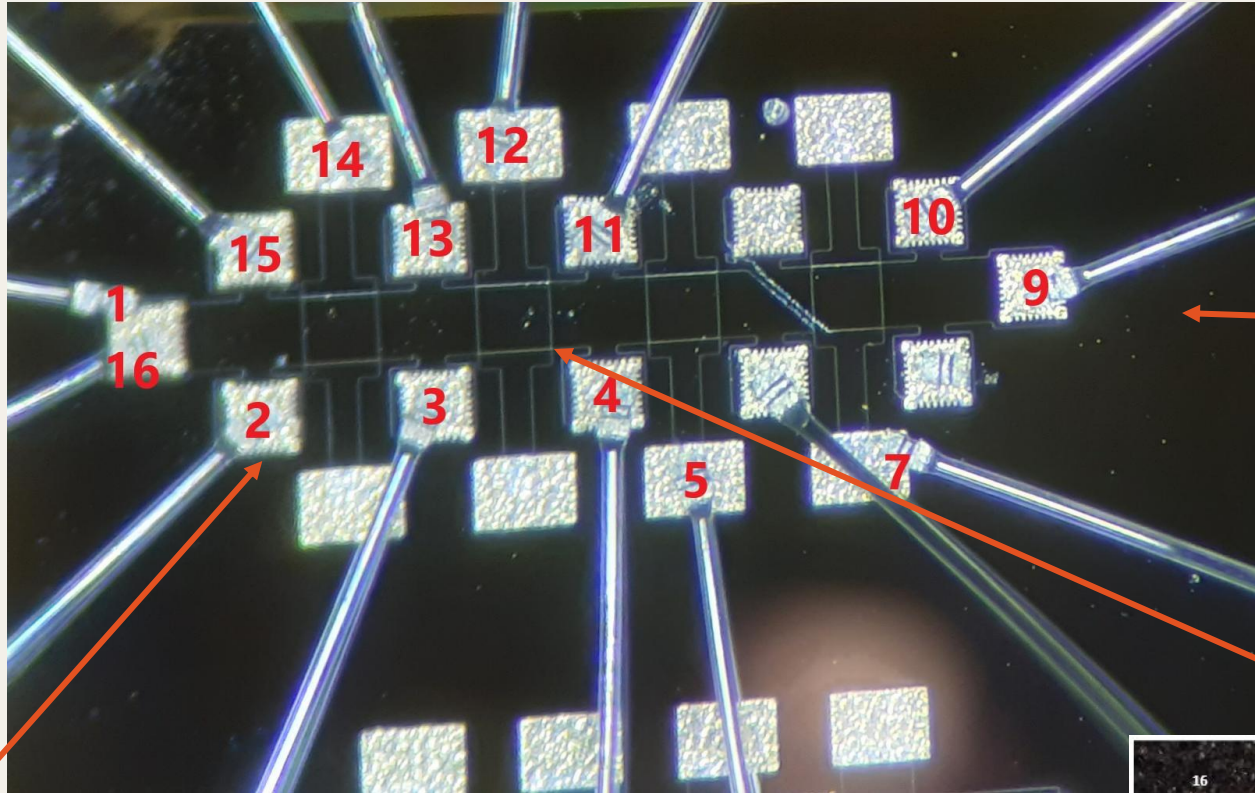
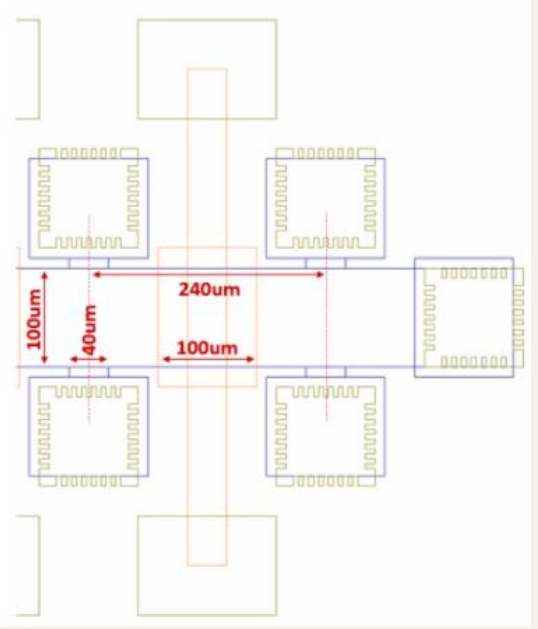
Sample



Device architecture

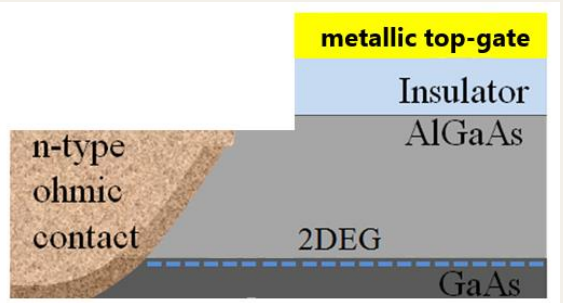
Doping	% Al	Spacer	Depth	300 K		4K DARK		4K LIGHT	
				n	μ	n	μ	n	μ
Uniform	25/36	370	670 Å	$3.0E+11$	$7.2E+03$	$2.5E+11$	$3.3E+06$	$3.9E+11$	$5.0E+06$

cm^{-2} cm^2/Vs

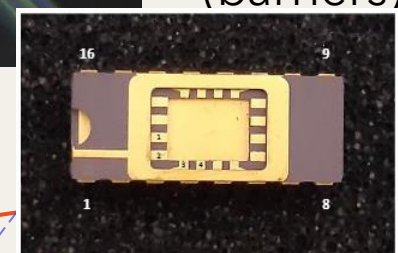


High mobility GaAs/AlGaAs wafer from Weizmann institute grown by Vladimir Y. Umansky

Aluminium gates (barriers)

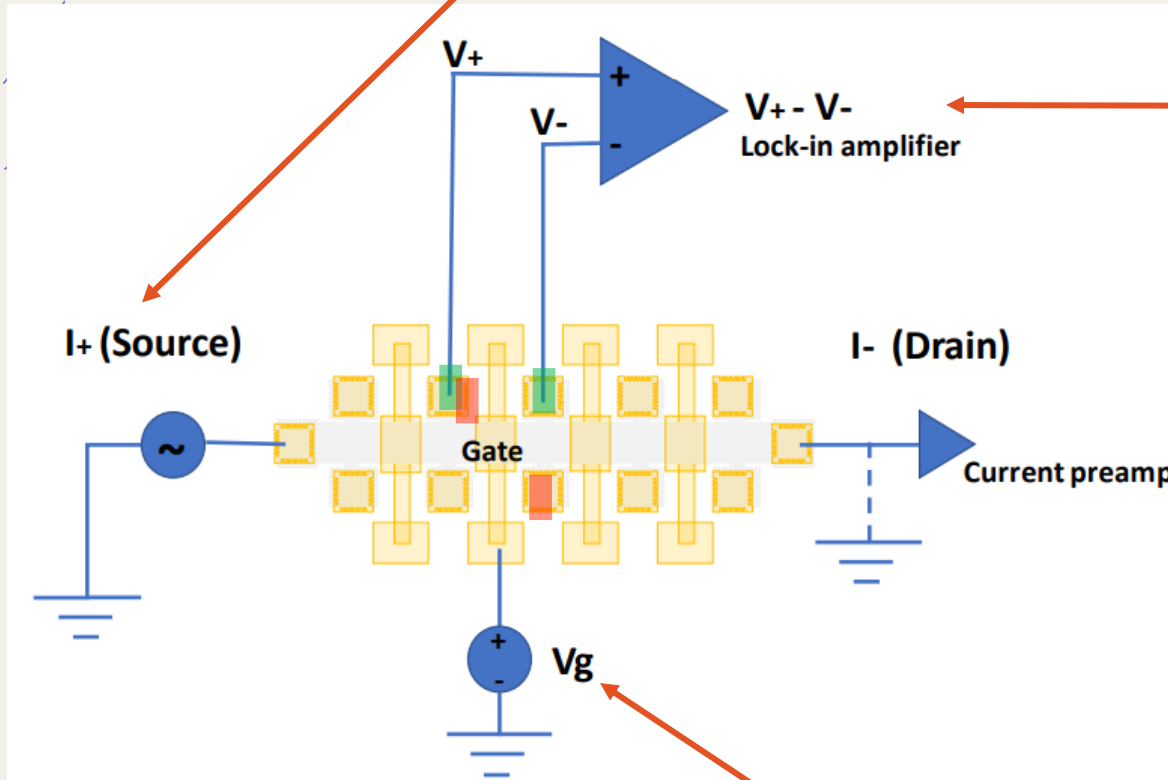


AuGeNi Ohmic contacts



Measurement setup

AC current bias or voltage bias



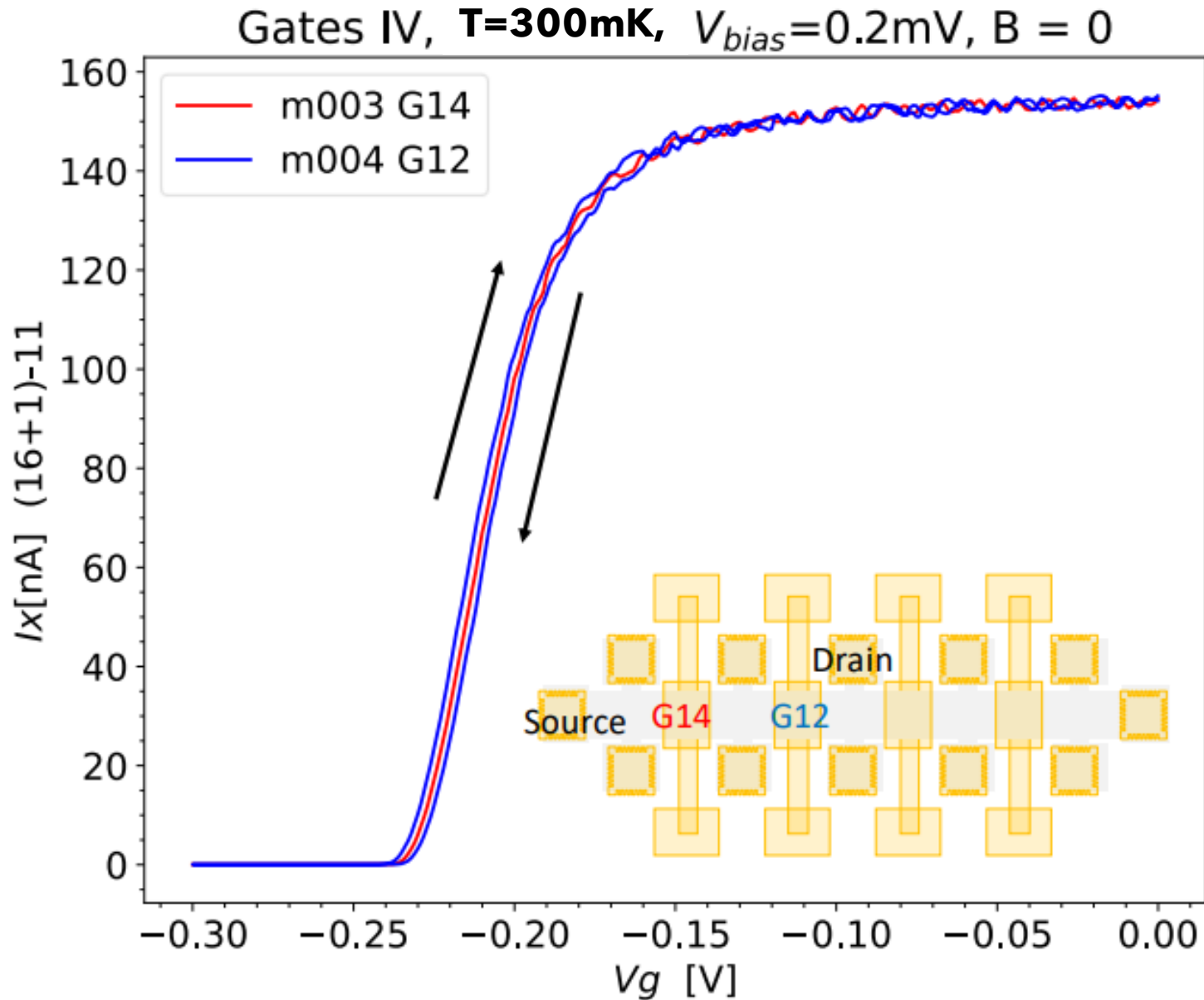
One lockin to measure longitudinal voltage drops

One lockin to measure diagonal or transversal voltage drops

- How good is the equilibration or mixing (zero voltage) ?
- Mixing breakdown voltage at finite gate bias?

DC gate voltage bias to reconfigure v

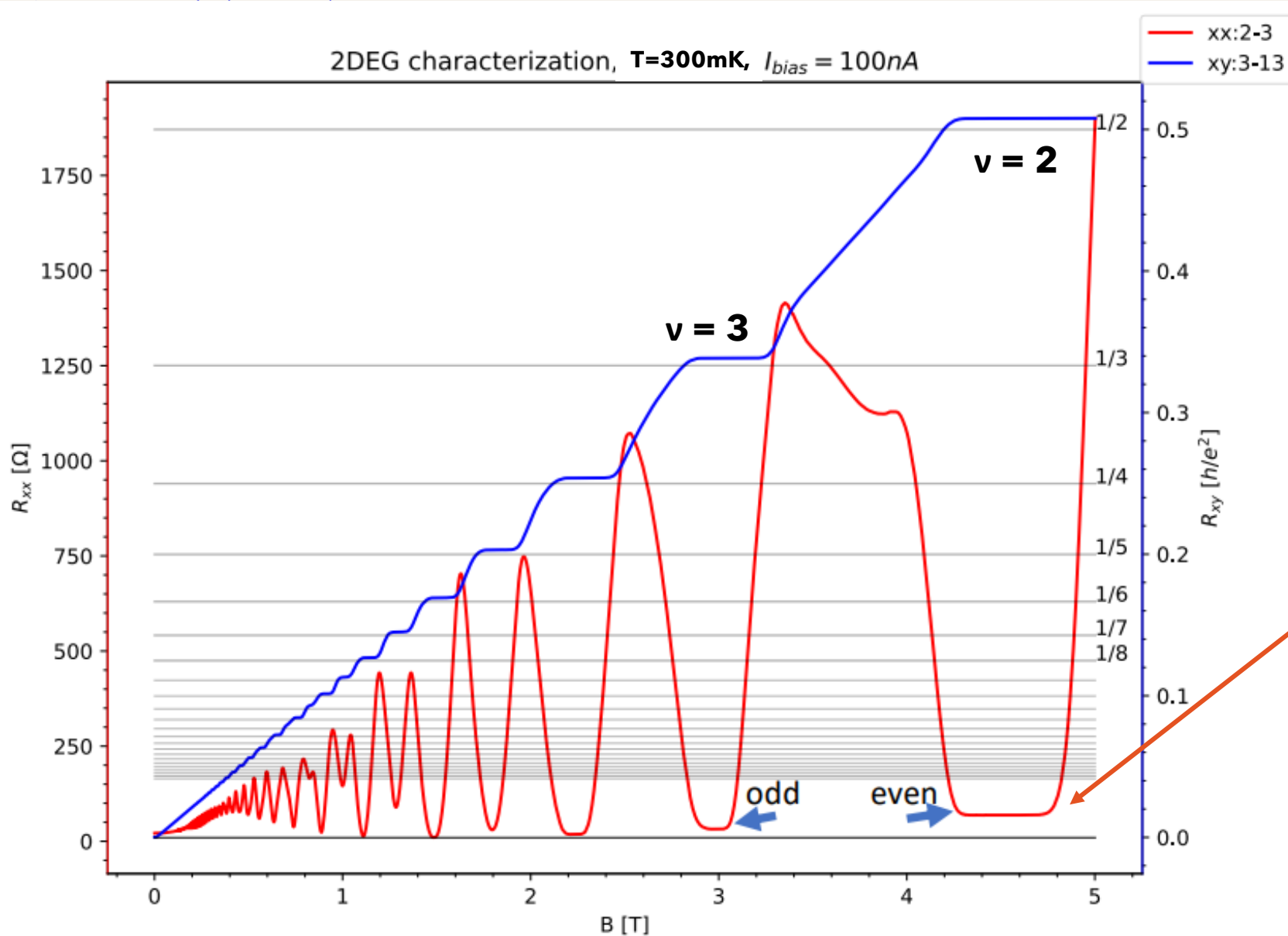
Gates characterization



Pinch-off at -0.25 V
(**barrier realization**)
Slight hysteresis

Contacts working correctly
At $\mathbf{B = 0}$

2DEG characterization: transport parameters



$$W/L_{\text{Hallbar}} = 2.4$$

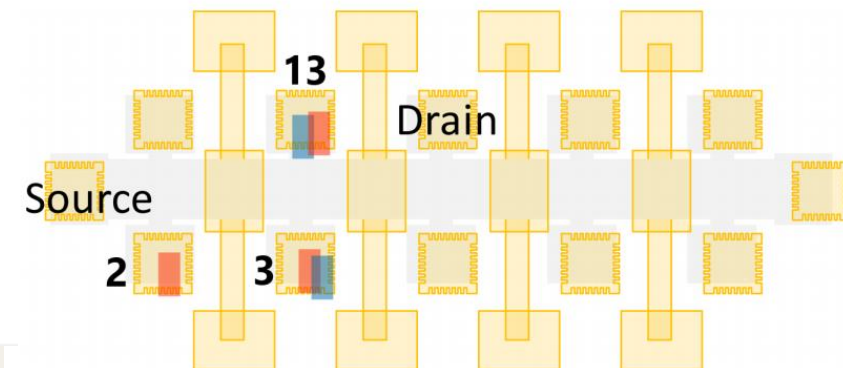
$$\mu = 3.37 \times 10^6 \text{ cm}^2/(\text{Vs})$$

$$n = 2.2 \times 10^{11} \text{ cm}^{-2}$$

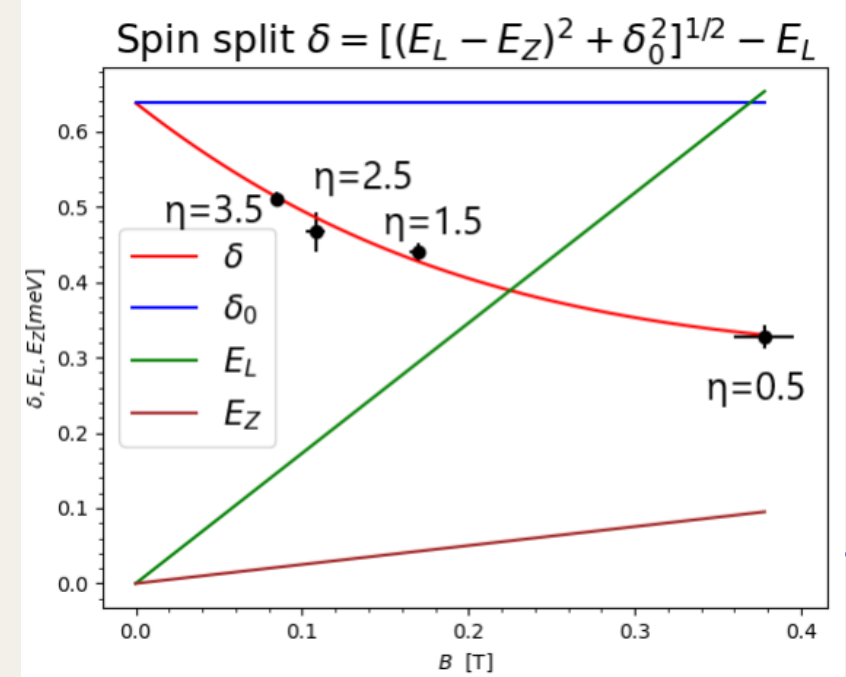
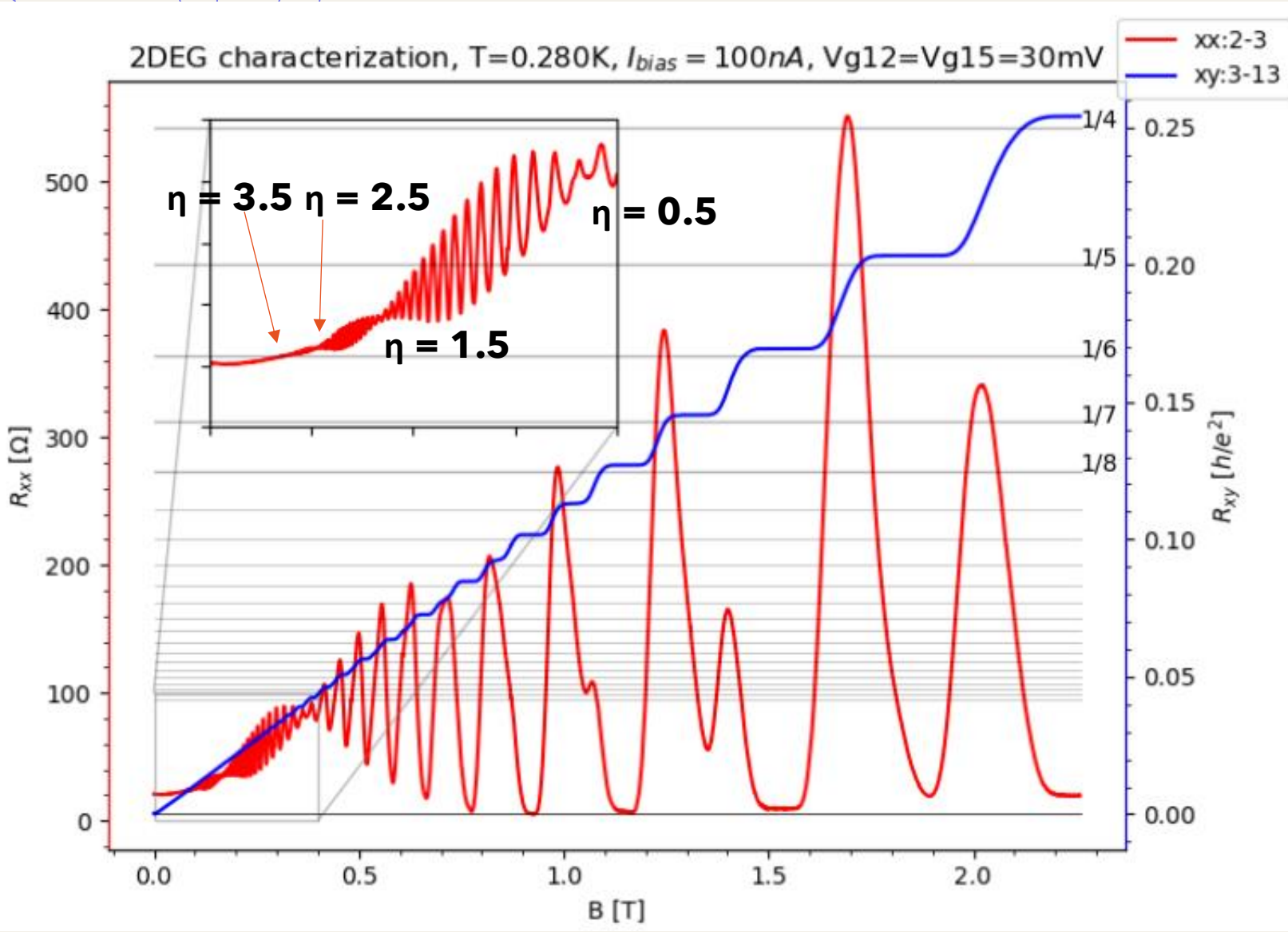
$$\tau = 128 \text{ ps}$$

Parallel conduction ?

$B > 0$ anticlockwise chirality
 $B < 0$ clockwise chirality

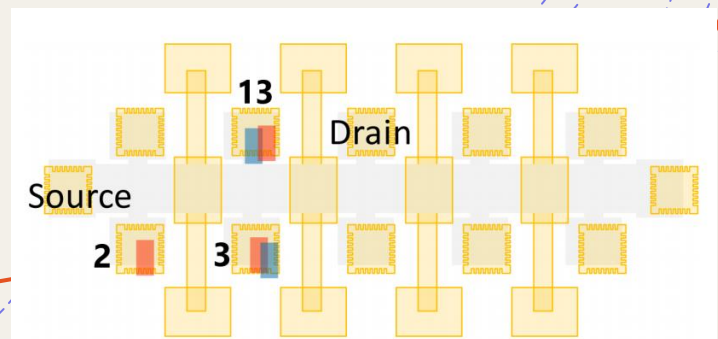


2DEG characterization: beating features



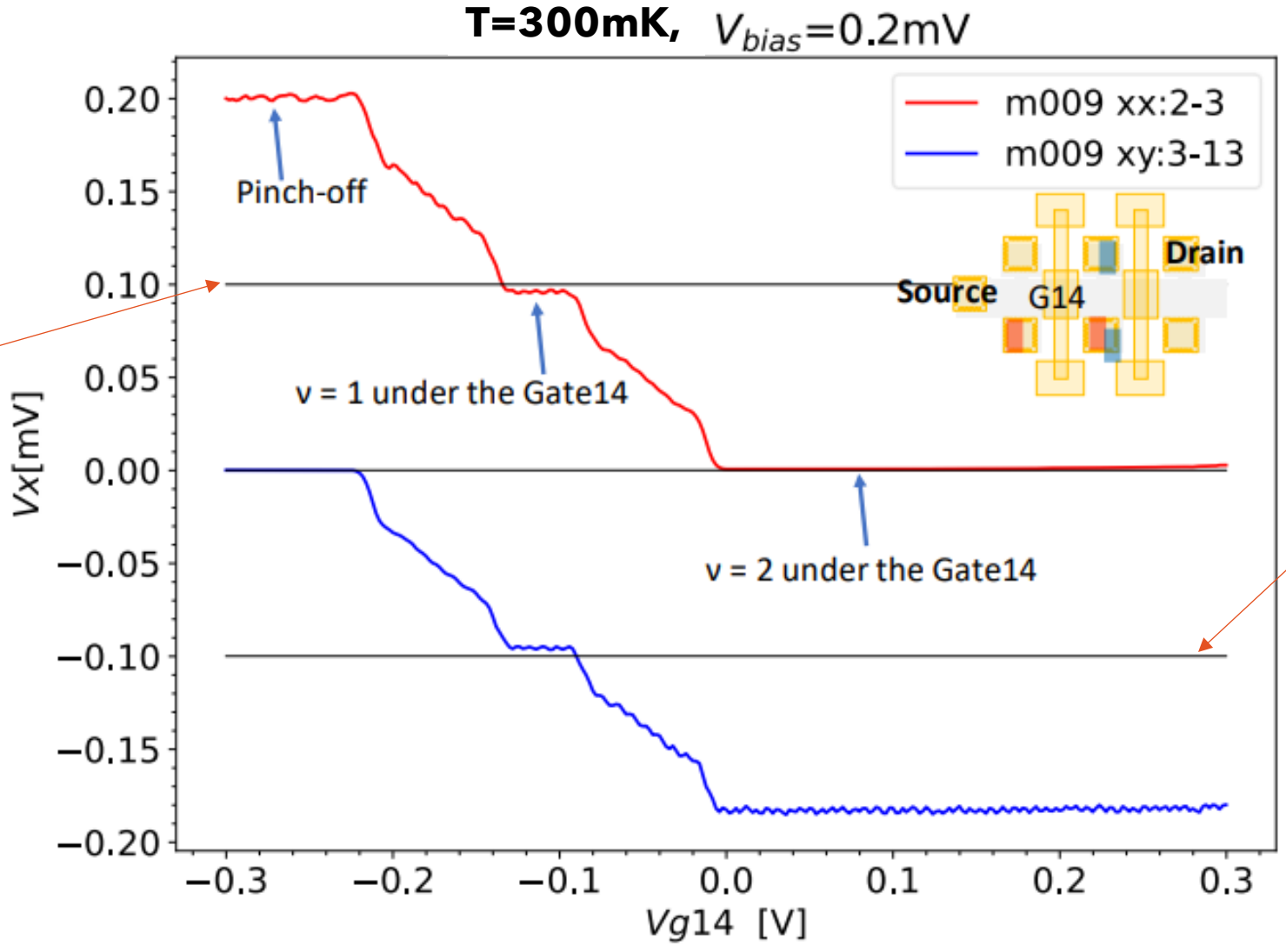
$g^* = -0.29 \pm 0.06$
 $\delta_0 = 0.638 \pm 0.007 \text{ meV}$
 $E_L(\nu = 2) = 0.5 \text{ eV}$
 $E_Z(\nu = 2) = 0.1 \text{ meV}$

$$\delta = \eta \hbar \omega c(B_{node})$$



Gate characteristics at $\nu = 2$

Gate14 mixer calibration. **Correct control of ν under the gate.**

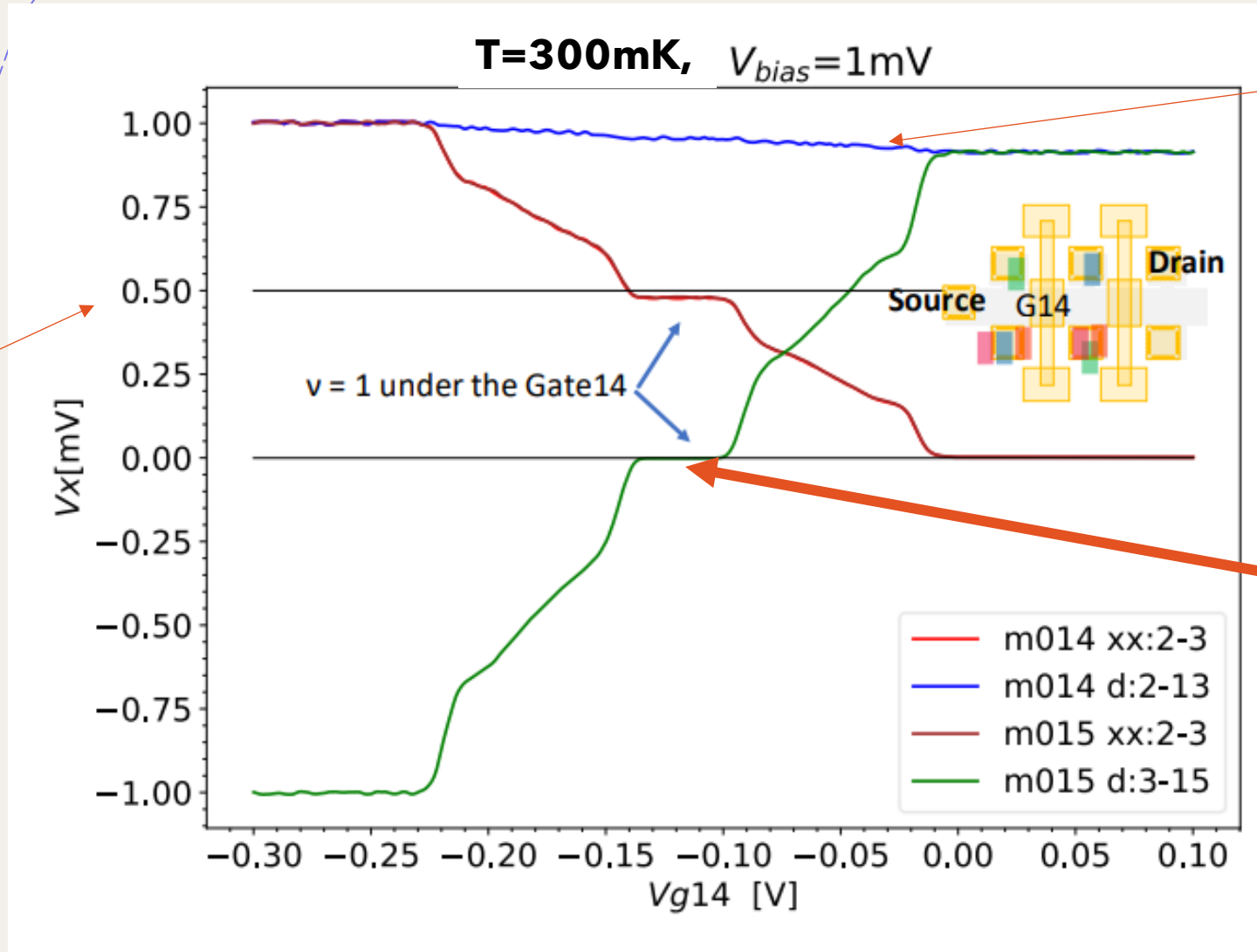


$V_{bias}/2$

$-V_{bias}/2$

Gate characteristics at $\nu = 2$

Gate14 single mixer operation verification



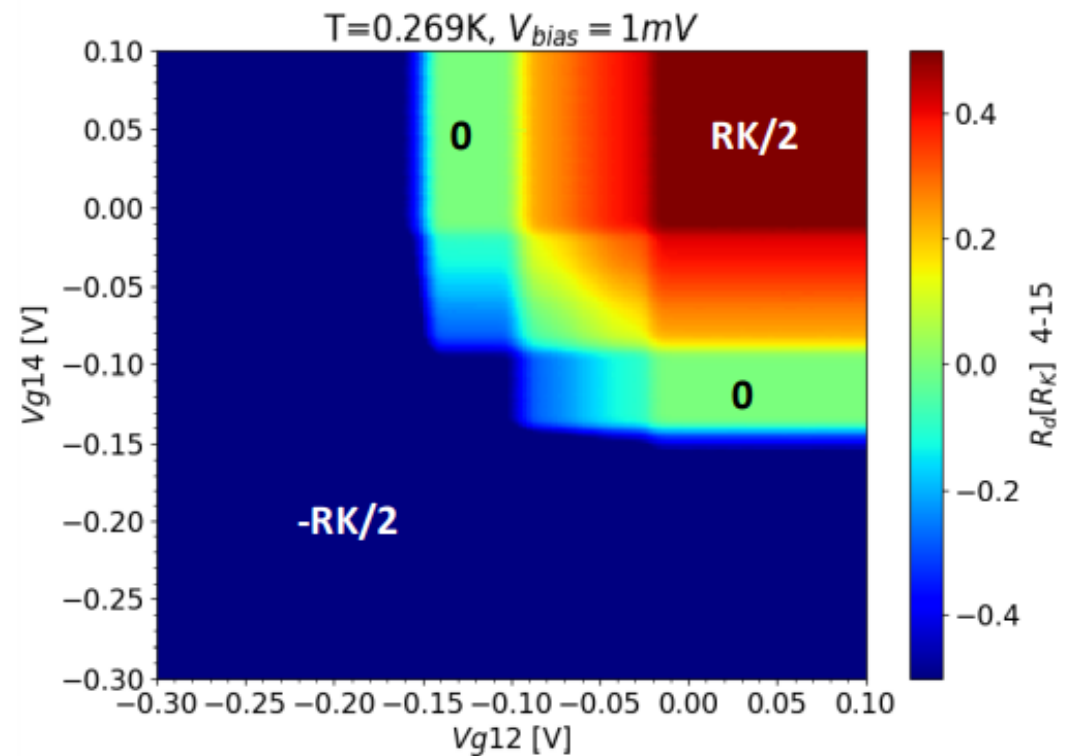
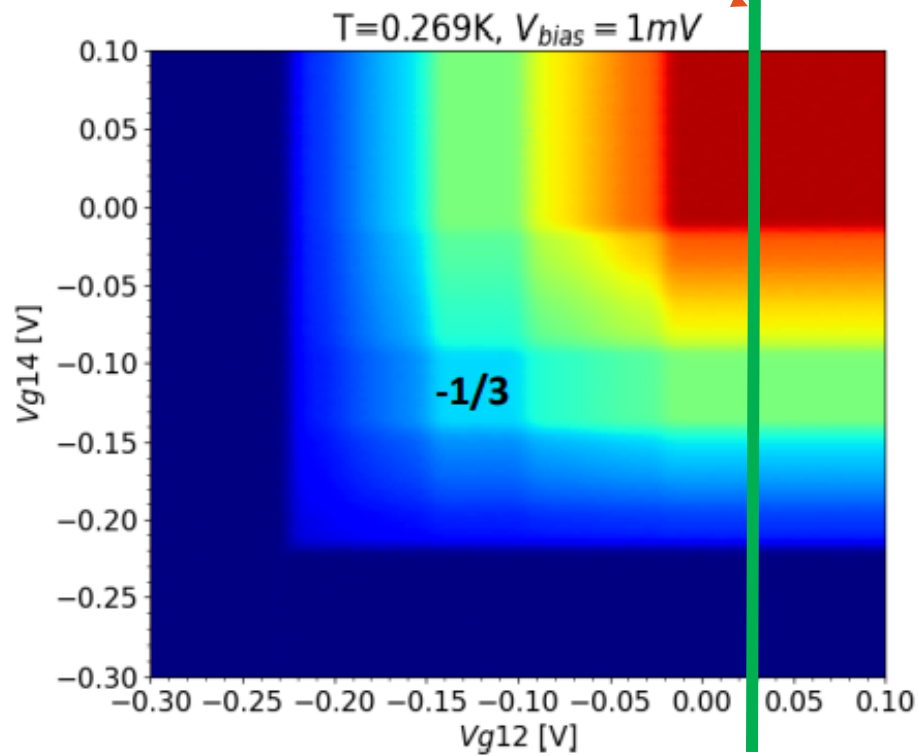
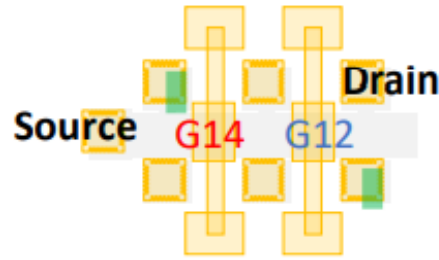
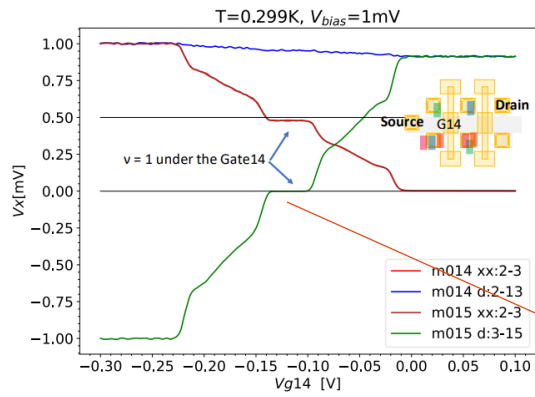
$V_{bias}/2$

Deviation from V_{bias} due to $R_{xx} \neq 0$

Correct equilibration Averages on the diagonal

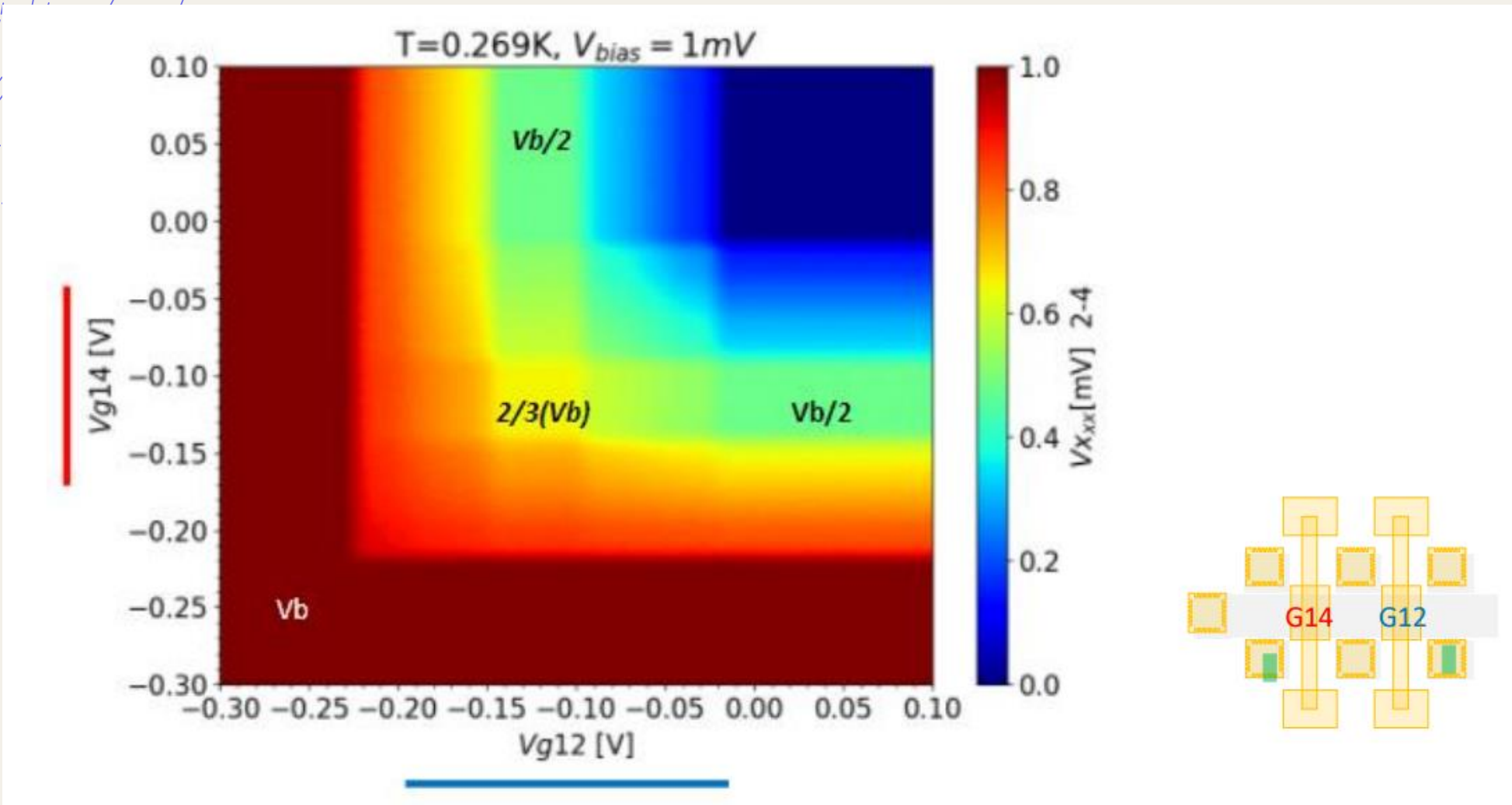
Gate characteristics at $\nu = 2$

Gate 14 & 12 diagonal voltage drops and diagonal 4w resistance (2D map)

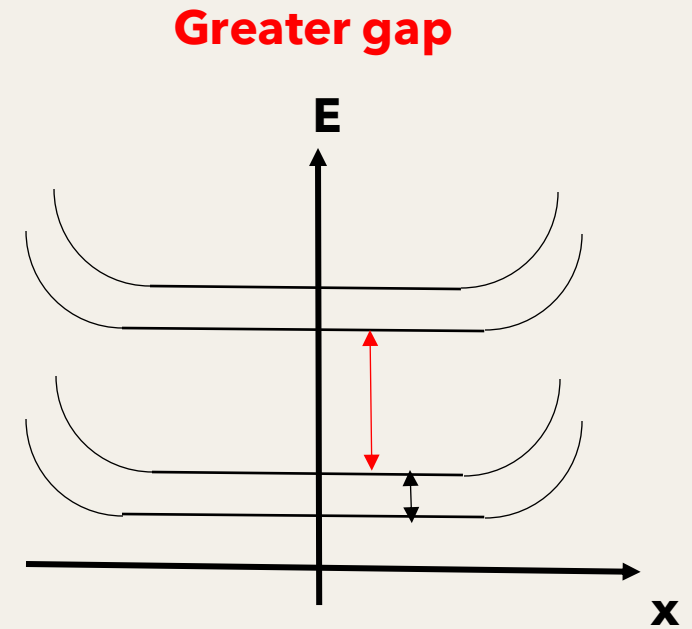
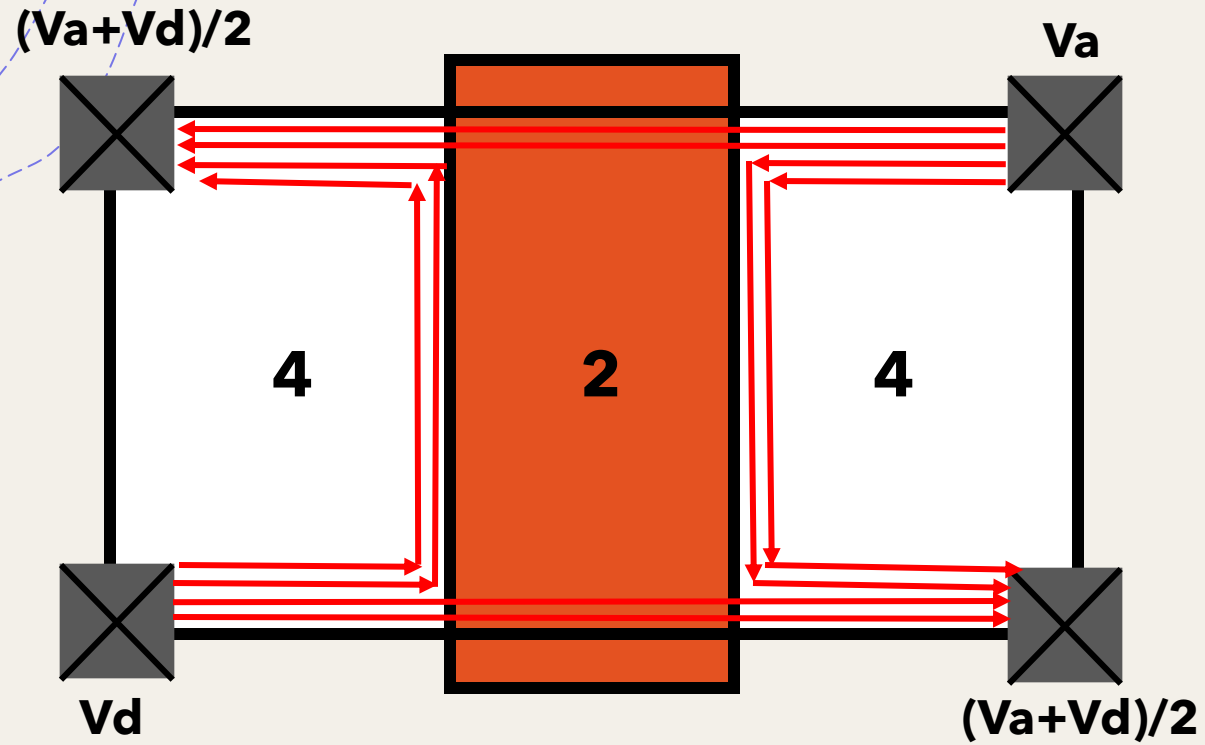


Gate characteristics at $\nu = 2$

Gate14&12 longitudinal voltage drops (2D map)

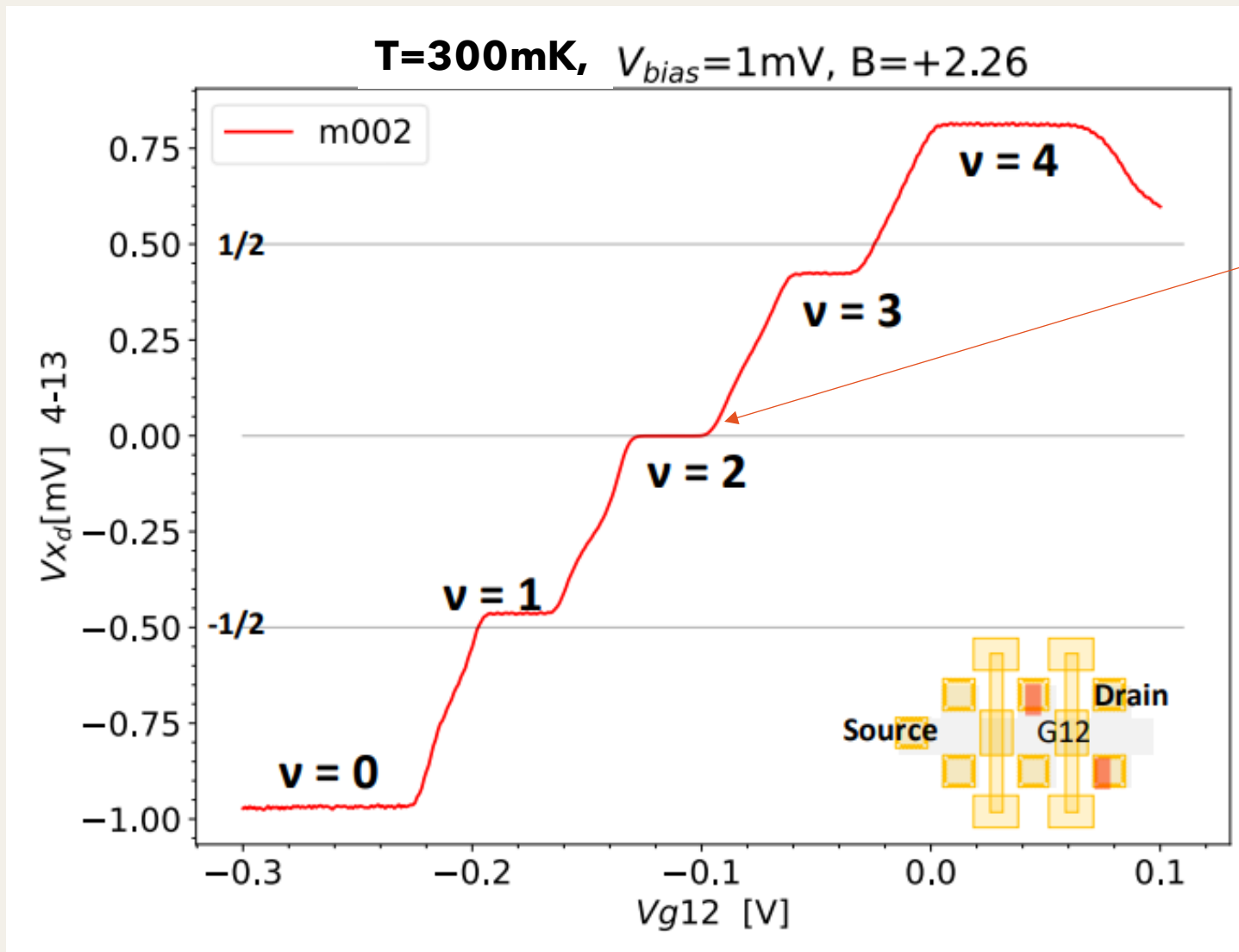


Alternative working scheme for the mixer

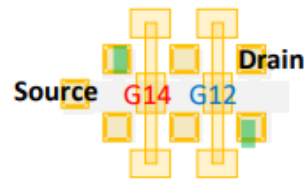
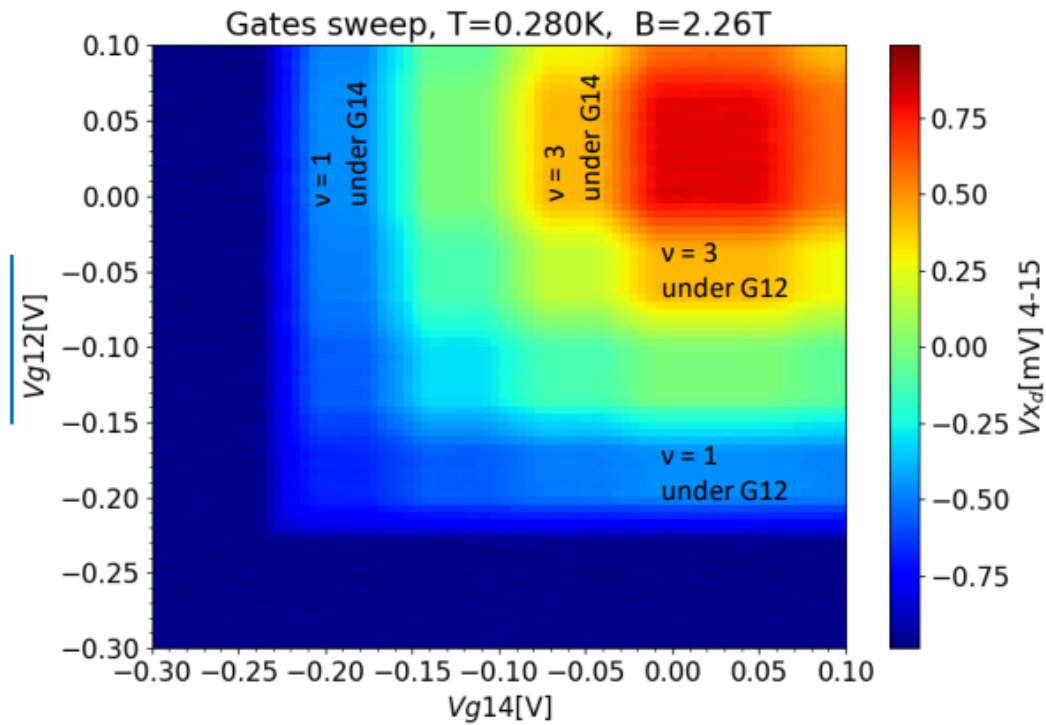


Gate characteristics at $\nu = 4$

Gate14 mixer equilibration check



Correct equilibration
Averages on the
diagonal

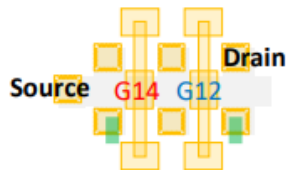
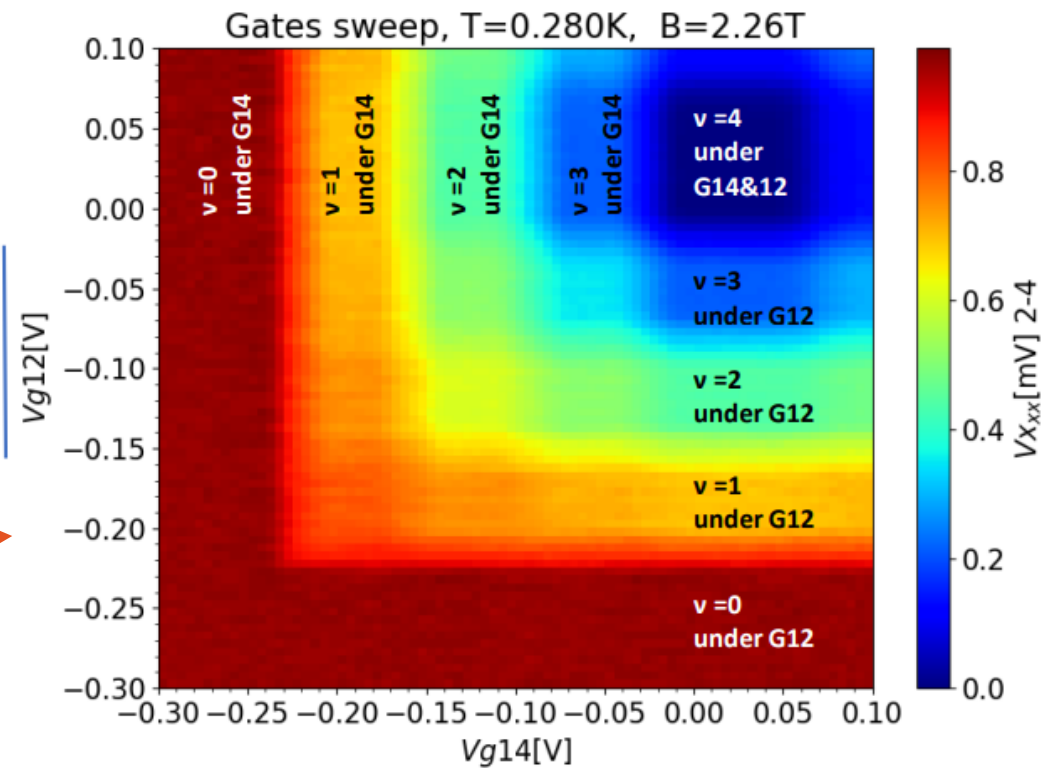


Gate characteristics at $\nu = 4$

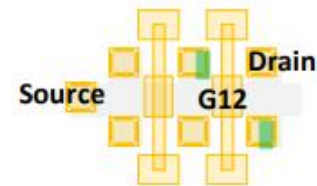
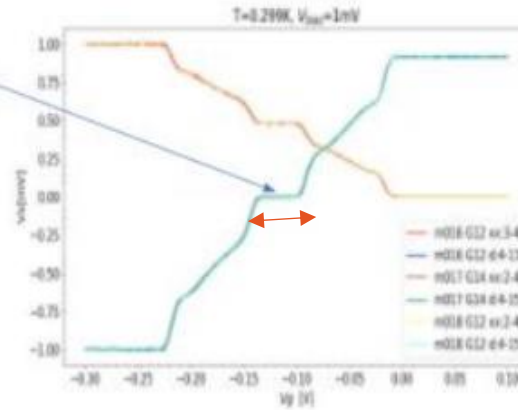
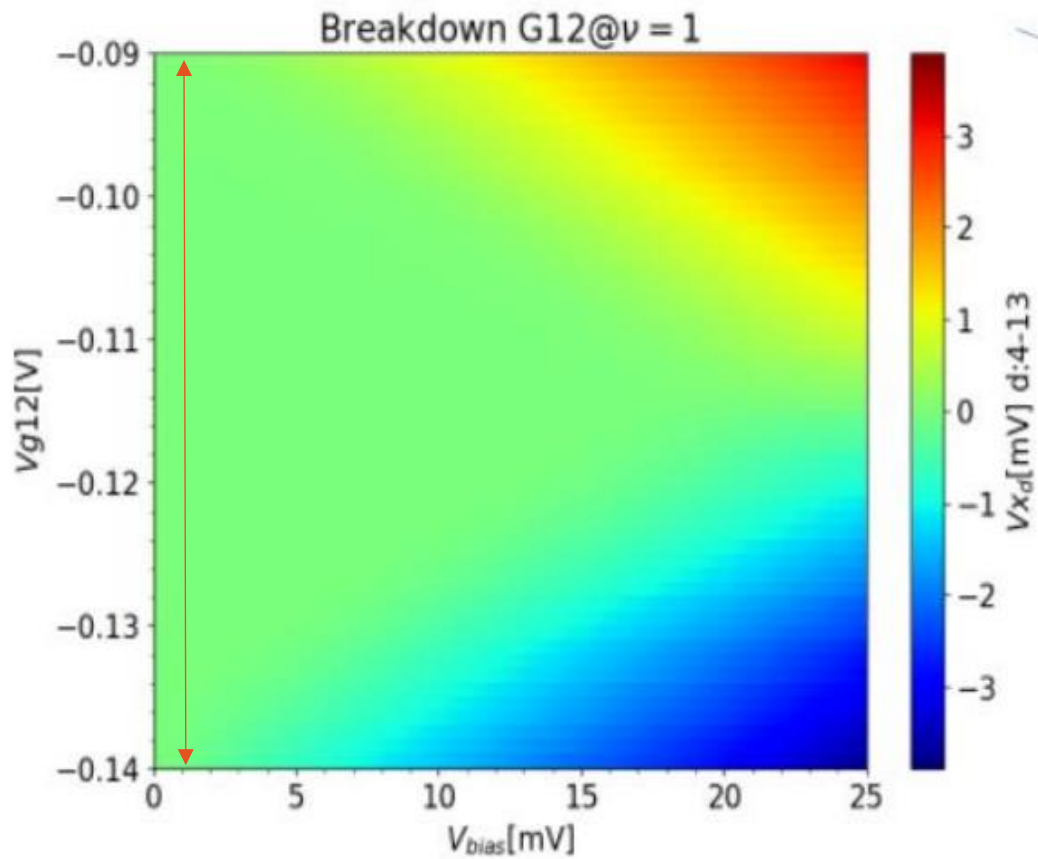
Gate 12 & 14 diagonal voltage drops (2D maps)

Diagonal

Longitudinal



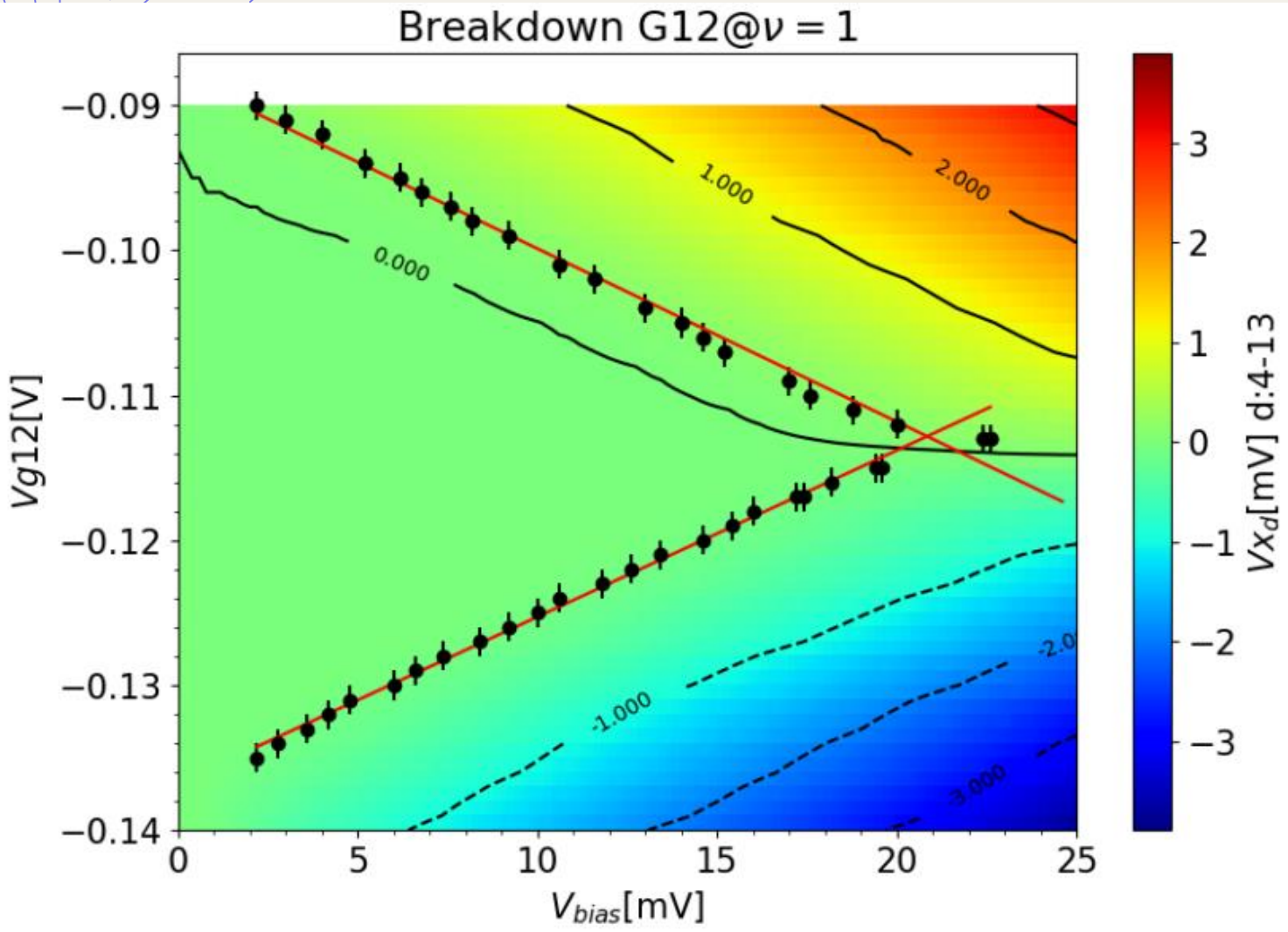
Quantum Hall breakdown (max voltage bias applicable)



**Colormap of gate12 at $\nu = 1$
diagonal voltage**

And Hall bar at $\nu = 2$

Max voltage bias values



$0.794 \pm 0.008 \mu\text{A}$

v_{gate} v_{bar}	1	2	3	4
2	$20.8 \pm 0.2 \text{ mV}$	-	-	-
4	$16.0 \pm 0.6 \text{ mV}$	$14.4 \pm 0.2 \text{ mV}$	$15 \pm 1 \text{ mV}$	$10.3 \pm 0.1 \text{ mV}$

$I_c \geq 0.3 \mu\text{A}$

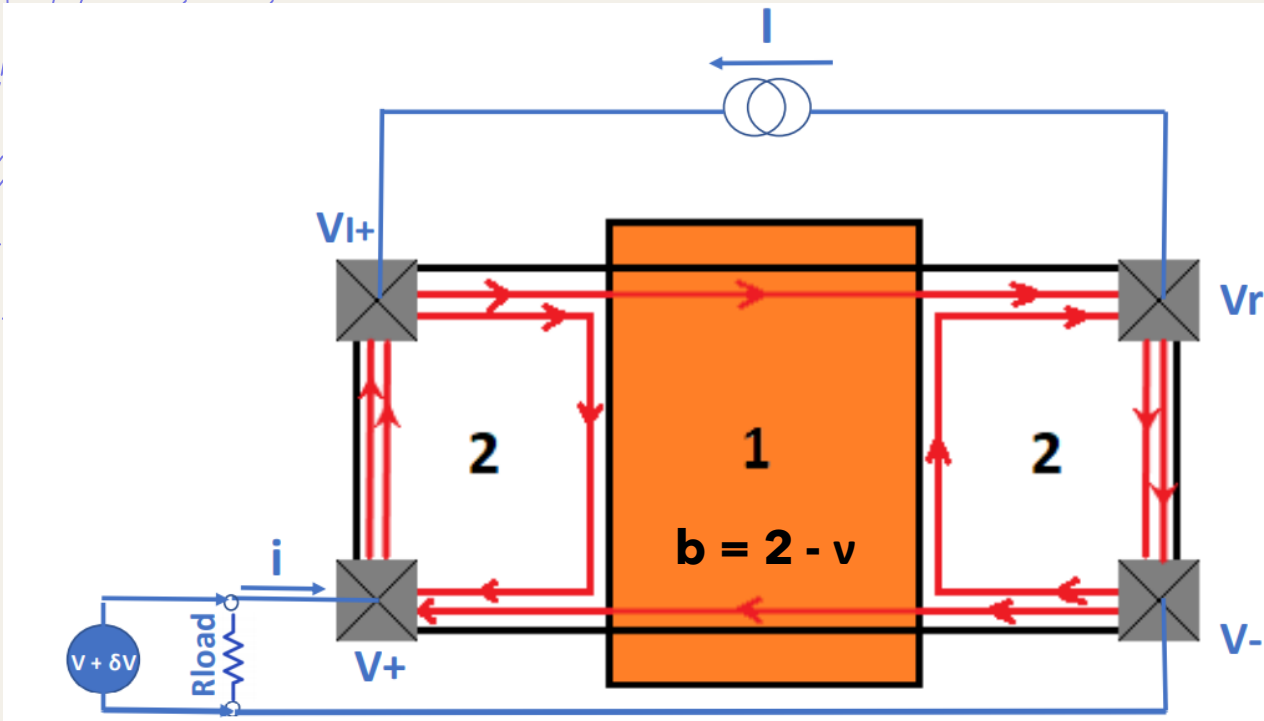
$I_c > 1 \mu\text{A}$

Max voltage ~ 10 mV

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Study of external influences on the precision: R_{out}



$$\delta V = -iR_{out}$$

$$(V + \delta V)/I = (R_{load}/(R_{load} + R_{out}))R$$

R_{4w}
4-w real
resistance

4-w ideal
resistance

$$R = \mathbf{b(2 - b)}(R_K/2)$$

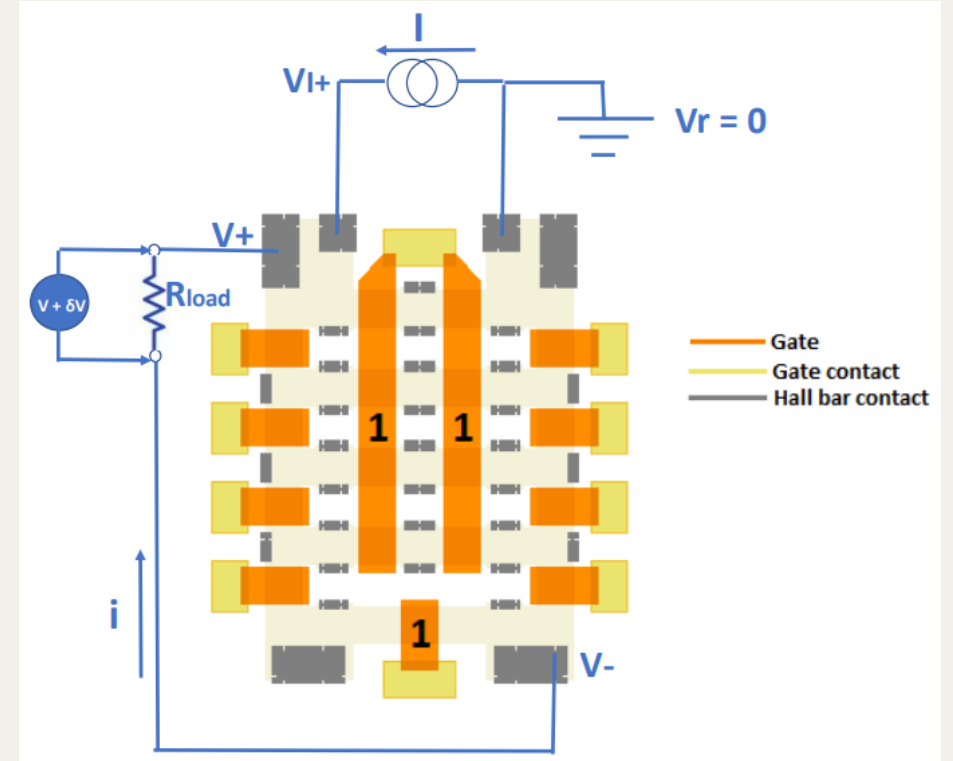
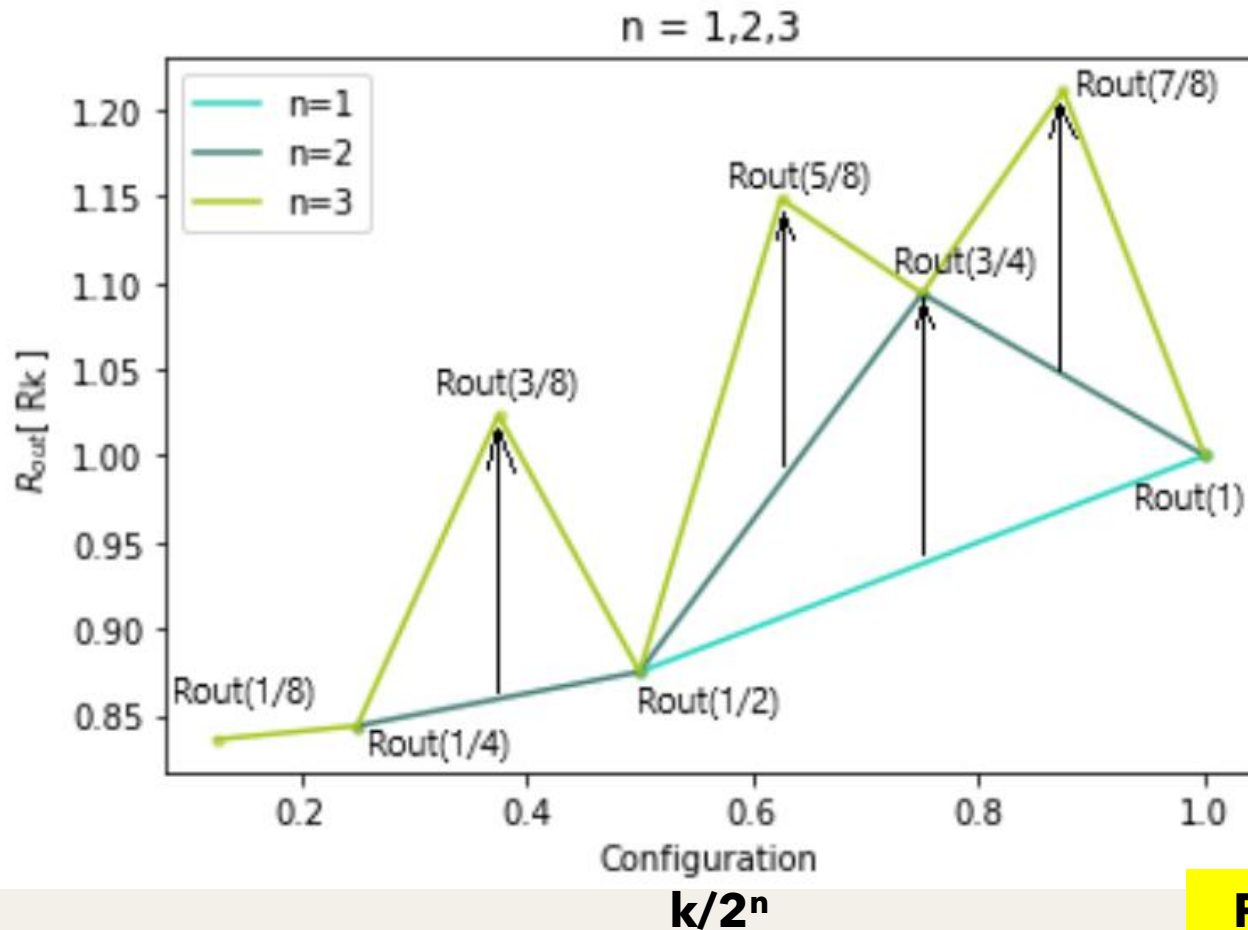
$$R_{4w} = \mathbf{(bR_L/(R_K + (2-b)R_L))}(R_K/2)$$

$$R_{out} = R_K/(2-b)$$

Configuration
dependent!

Numerical R_{out} results for the generic bisector

$$R_{out}((f_1 + f_2)/2) = \frac{R_{out}(f_1) + R_{out}(f_2)}{2} + h(n)$$

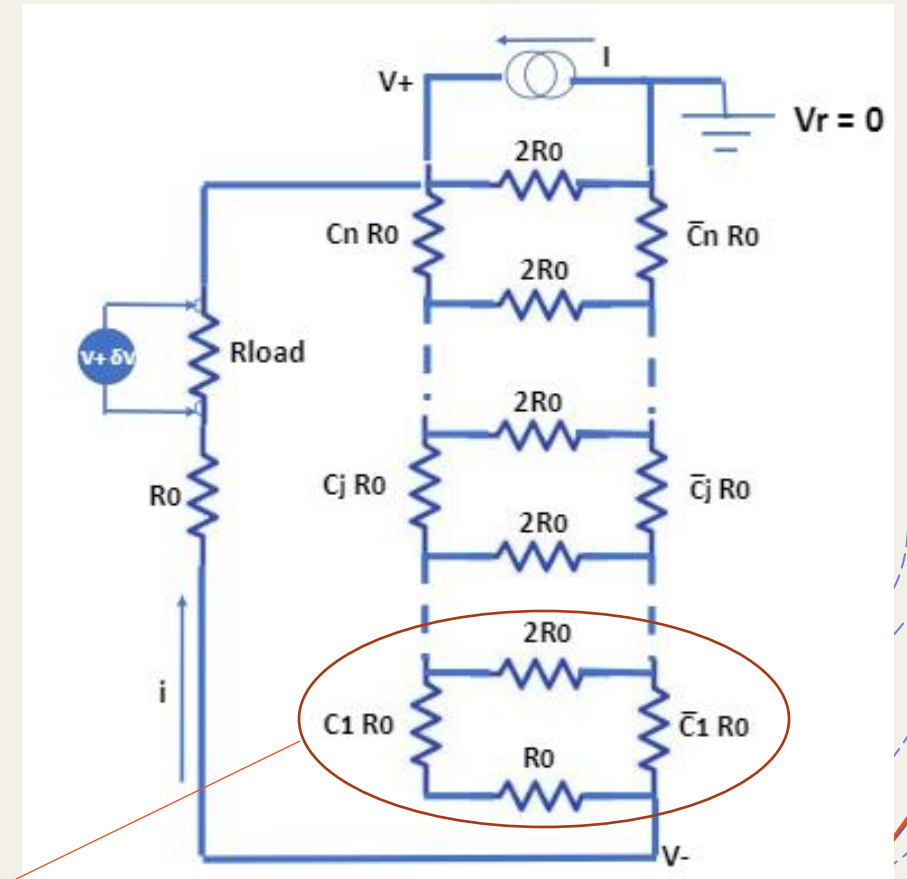
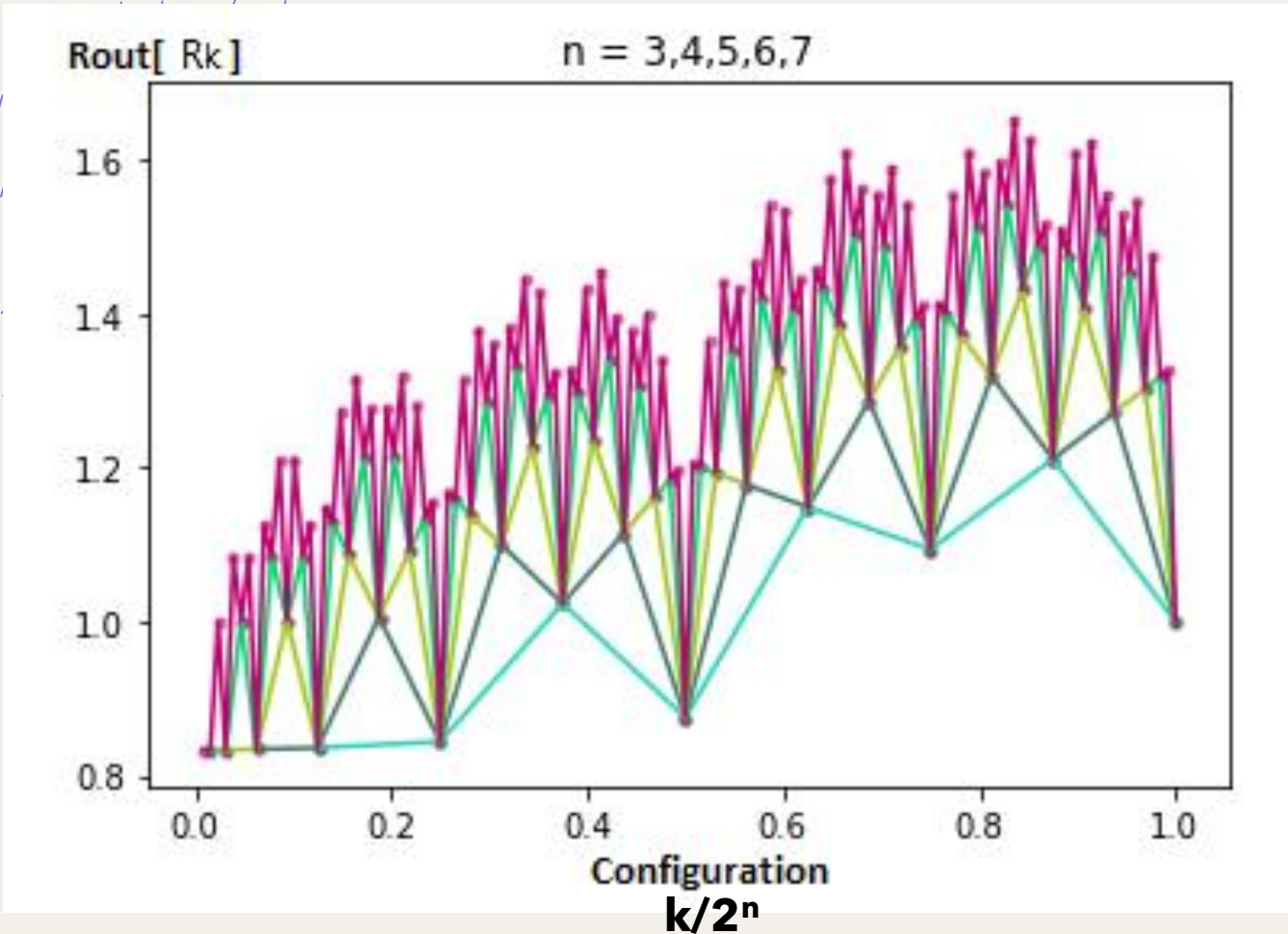


- $n = 1$ $2^n = 2$ $k = 1, 2$ $f = 0.5, 1$
- $n = 2$ $2^n = 4$ $k = 1, 2, 3, 4$ $f = 0.25, 0.5, 0.75, 1$
- ...

Fractal behaviour

Modeling QH potential drops as a resistive network

Rout is limited for $n \rightarrow \infty$



$$h(n) = \frac{1}{8} \sum_{i=0}^{n-1} 2^{-2i}$$

Simplifying each stage and finding R_{out}

Conclusions

- Correct equilibration of the edge channels for the bisection scheme
- Breakdown voltage was found to be ~ 10 mV
- Limited and predictable R_{out}

What application ?
Other 2D materials ?

The background features a light beige gradient. In the top-left corner, there is a white circle partially cut off by the edge, with several blue dashed lines curving downwards and to the right. In the bottom-right corner, there is another white circle partially cut off, with several blue dashed lines curving upwards and to the left. A solid orange line also curves upwards from the bottom right towards the center.

Grazie per l'attenzione